

September 26, 2013  
Cheiron School 2013

X-ray Beamline Design 1  
**X-ray Monochromator**

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**SPring-8/JASRI**

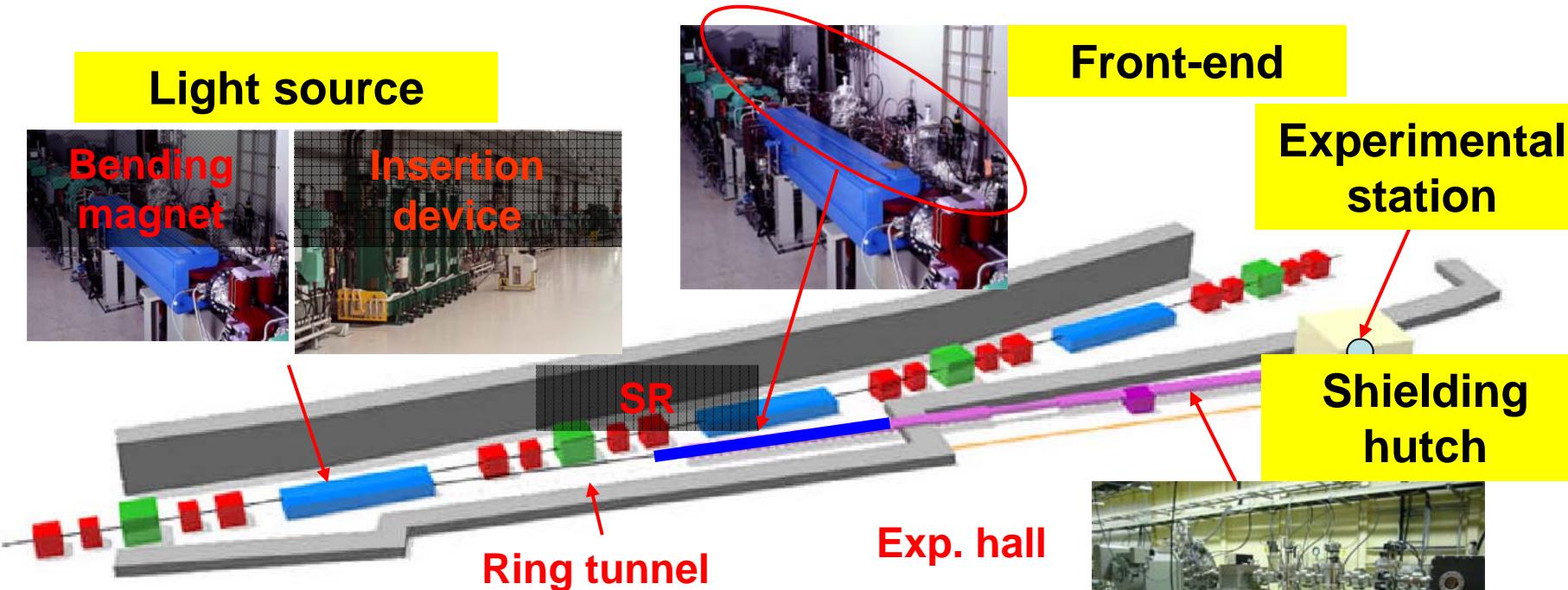
# Outline

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1. Introduction
2. Light source
3. X-ray Monochromator
  - Fundamental of Bragg reflection
  - Dynamical theory
  - DuMond diagram ~ extraction of x-rays from SR
  - Double crystal monochromator
  - Crystal cooling
4. Example of beamlines at SPring-8
5. Summary

# Beamline structure

Beamline = “Bridge” between light source & experimental station



→ Transport and processing of photons

photon energy, energy resolution,  
beam size, beam divergence, polarization,..

→ Vacuum

protection of ring vacuum and beamline vacuum

→ Radiation safety

Shielding and interlock

Optics & transport

Monochromator, mirror  
shutter, slit  
pump,..

# Light sources & X-ray optics

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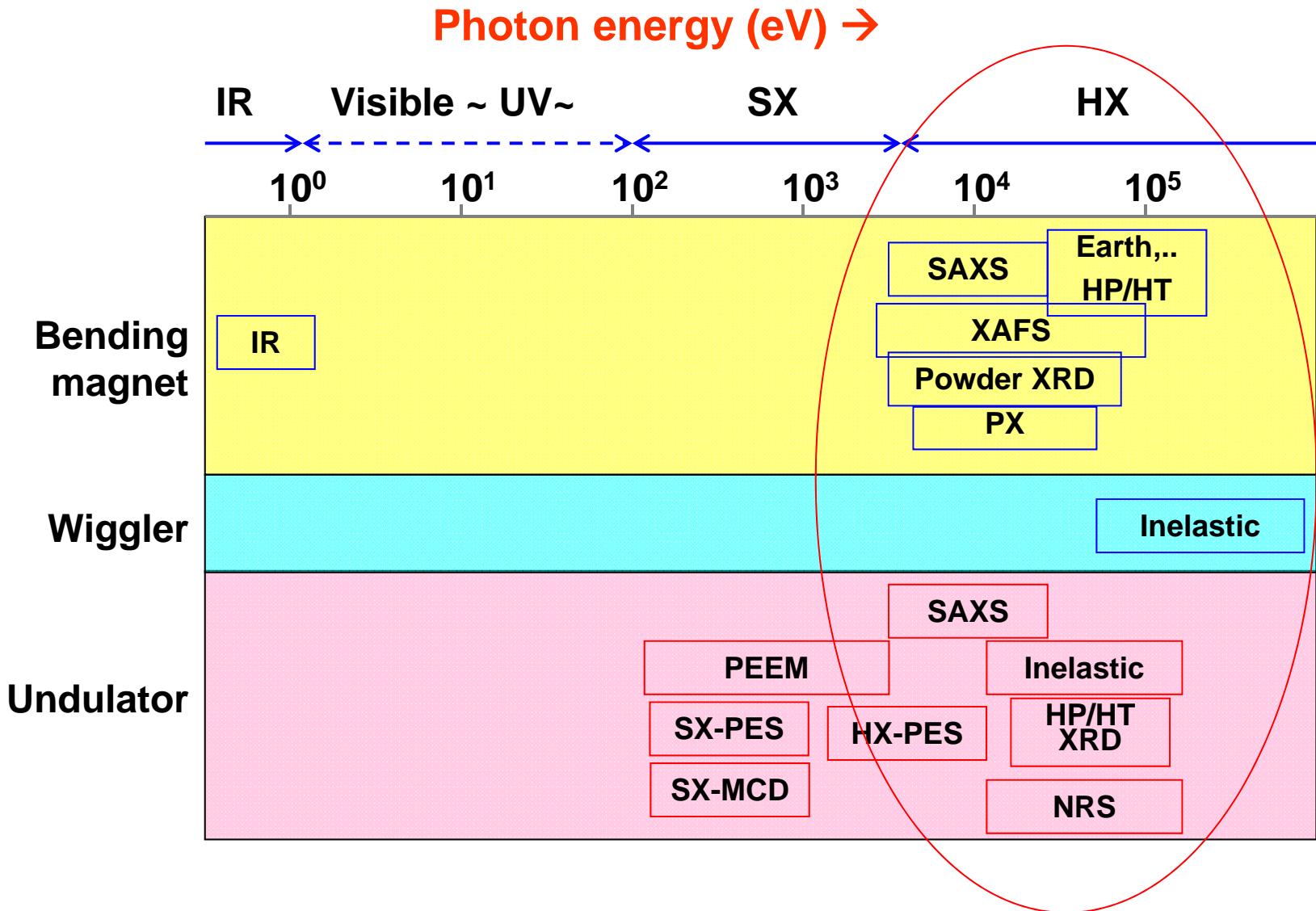
Check points to be considered for your SR application:

- White or monochromatic
- Energy range
- Energy resolution
- Flux & flux density
- Beam size at sample (micro beam?,...)
- Beam divergence/convergence at sample (Resolution in k-space)
- Higher order elimination w/ mirror
- Polarization conversion
- Spatial coherency

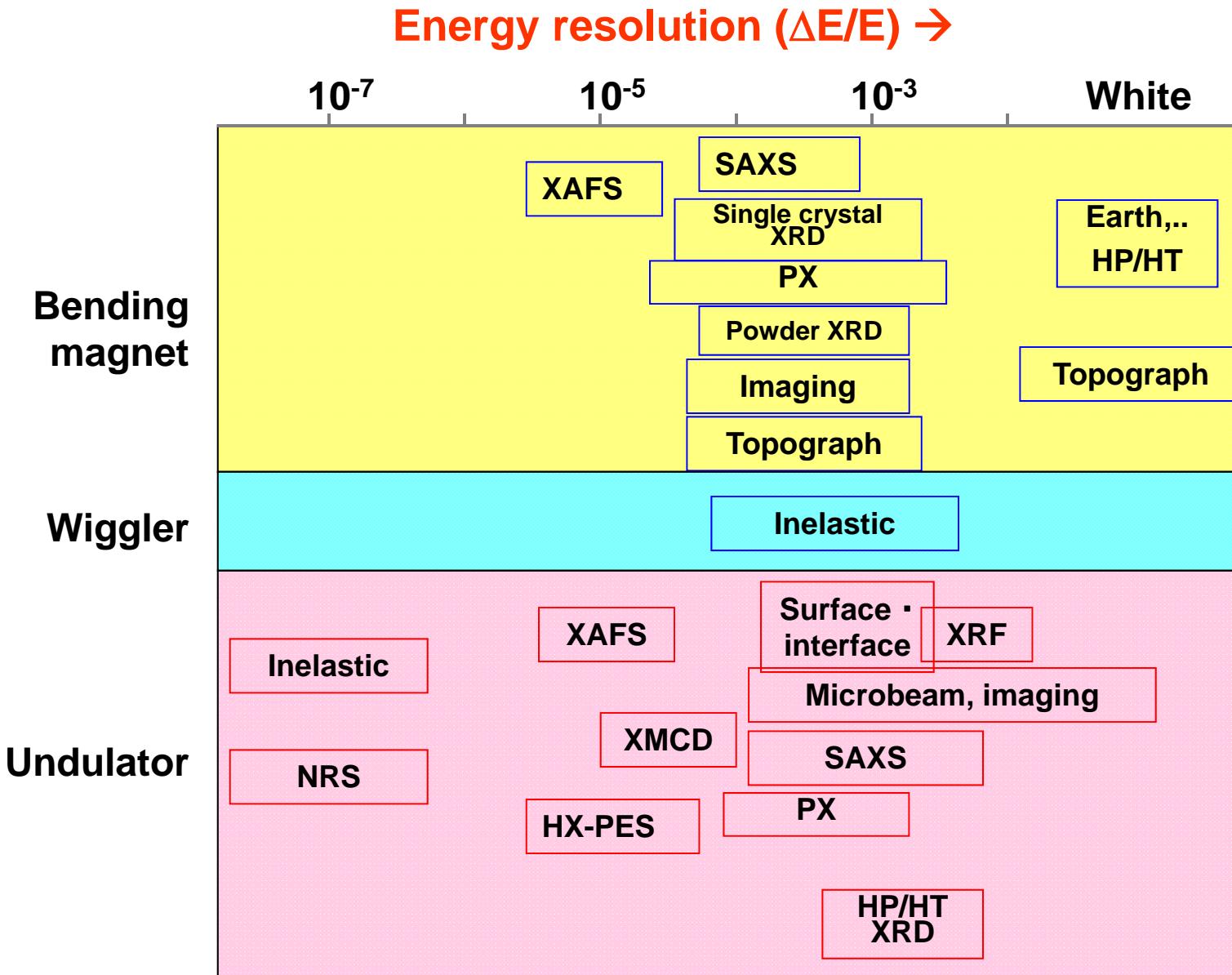
....

→ Light source, monochromator, mirror,  
and other optical devices and components

# BL classification (energy region)



# BL classification (energy resolution)



# Light sources (1)

Bending magnet or insertion devices ?

Bending magnet:

for wide energy range, continuous spectrum

for wide beam application for large samples

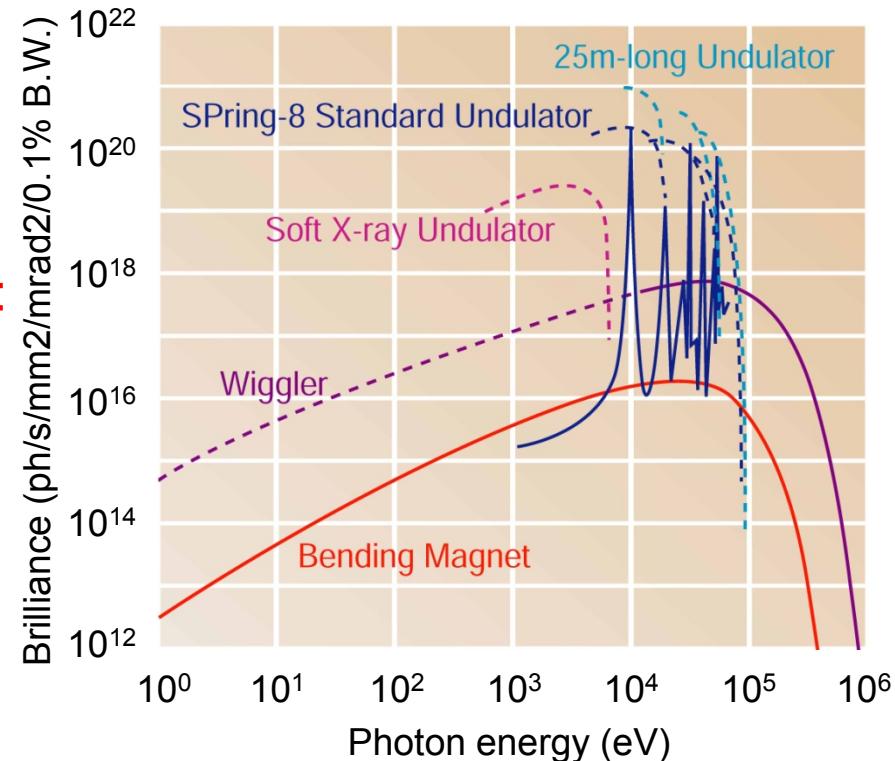
Undulator (major part of 3GLS beamline):

for high-brilliance beam

for micro-/ nano-focusing beam

Wiggler:

for higher energy X-rays > 100 keV.



Power, brilliance, flux density, partial flux,..  
can be calculated using code.

e.g. "SPECTRA" by T. Tanaka & H. Kitamura

Brilliance for SPring-8 case

# Light sources (2)

Angular divergence and band width  
→ Core part we need

## Bending magnet

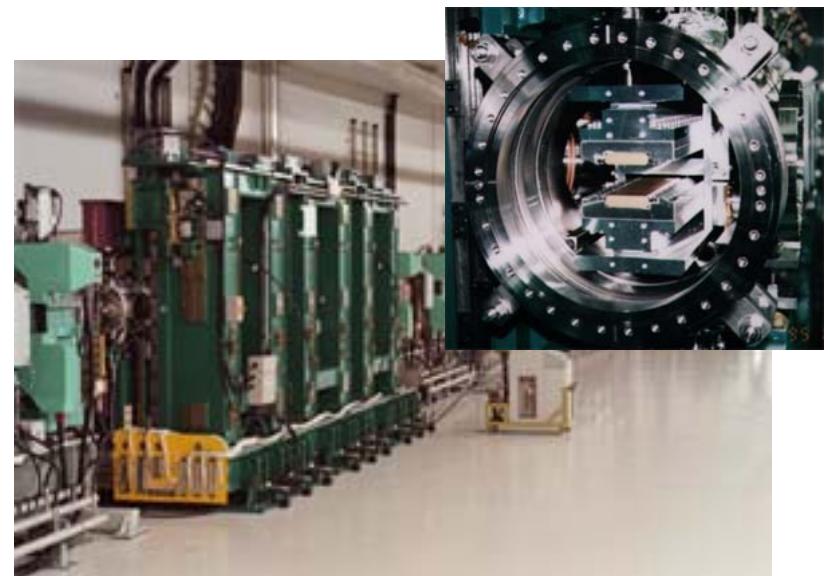
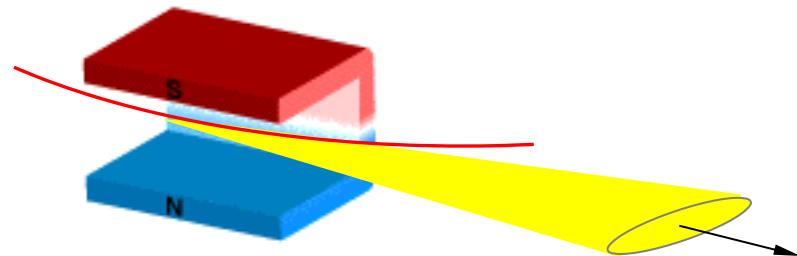
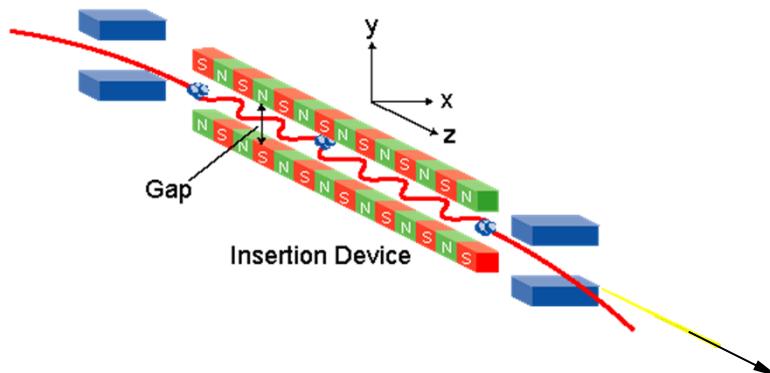
$$\sigma_{r'} \approx 0.597 \frac{1}{\gamma} \sqrt{\frac{\lambda}{\lambda_c}}$$

## Undulator

$$\sigma_{r'} \approx \sqrt{\frac{\lambda_n}{2N\lambda_u}} = \frac{1}{2\gamma} \sqrt{\frac{1+K^2/2}{nN}}$$

$$\frac{\Delta E}{E} \approx \frac{1}{nN}$$

Bending Magnet

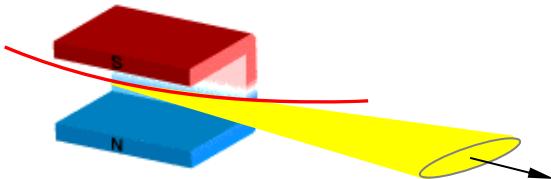


SPring-8 in-vacuum undulator

# Light sources (3)

Kilowatt of SR power → mostly eliminated before/by

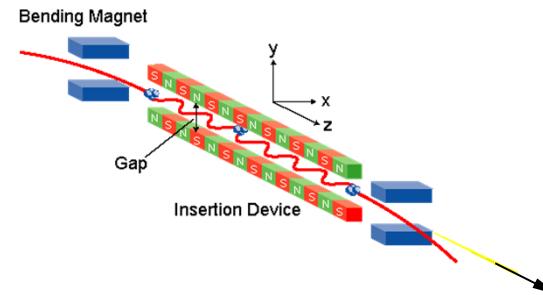
monochromator  
Bending magnet



Power distribution

$$\begin{cases} \psi_v \approx 1/\gamma \\ \psi_h \approx \text{const} \end{cases}$$

Undulator



$$\begin{cases} \psi_v \approx 1/\gamma \\ \psi_h \approx K/\gamma \end{cases}$$

$K$ : deflection parameter  
( $K = 0.5 \sim 2.5$ )

Total power

$$P_{\text{tot}}[\text{kW}] = 1.27 E^2 [\text{GeV}] B^2 [\text{T}] R [\text{m}] \phi [\text{rad}] I [\text{A}]$$

$$E = 8 \text{ GeV}, I = 0.1 \text{ A}, B = 0.68 \text{ T}, R = 39.3 \text{ m} \\ \rightarrow P_{\text{tot}} = 0.15 \text{ kW/mrad}$$

$$P_{\text{tot}}[\text{kW}] = 1.27 E^2 [\text{GeV}] \frac{1}{2} B_0^2 [\text{T}] L [\text{m}] I [\text{A}]$$

$$B_0 = 0.87 \text{ T}, L = 4.5 \text{ m} \\ \rightarrow P_{\text{tot}} = 14 \text{ kW}$$

# X-ray Monochromator

X-ray monochromator is key component for SR experiments:

- length gauge for structure analysis,
- energy gauge for spectroscopy,...

## Principle of x-ray monochromator

Photon energy tuning ← Bragg's law

Energy resolution ← source divergence, Darwin width,..

Flux (throughput) ← related to Darwin width

➔ Understanding the dynamical theory for large & perfect crystal

## Practical of the monochromator

- Double-crystal monochromator for fixed-exit

*Single-bounce monochromator is for limited case*

- Crystal cooling

High heat load depending on light source

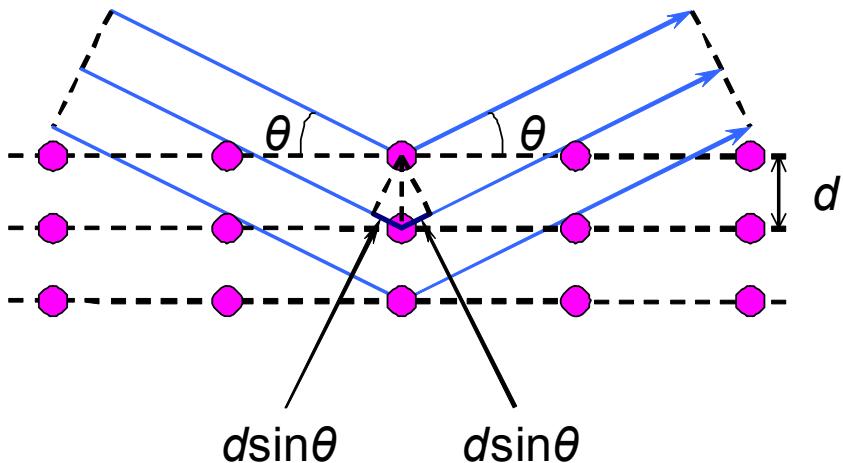
➔ Mechanical engineering issues

# Bragg reflection

## Bragg's law in real space

- 1) Phase matching on the single net plane by mirror-reflection condition.
- 2) Phase matching between net planes.

$$2d \sin \theta_B = m\lambda$$

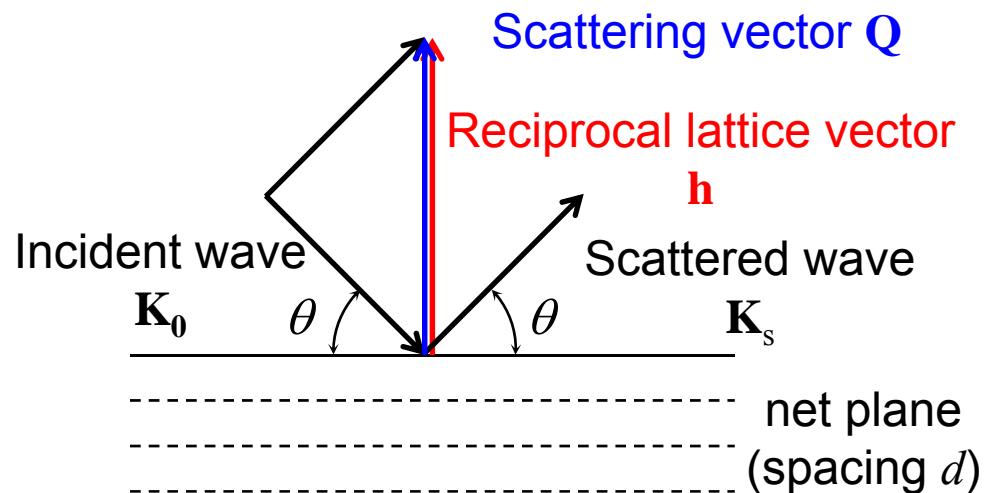


## Laue condition (Kinematical) in reciprocal space

$$\mathbf{Q} = \mathbf{K}_s - \mathbf{K}_0 = \mathbf{h}$$

Reciprocal lattice vector  $\mathbf{h}$

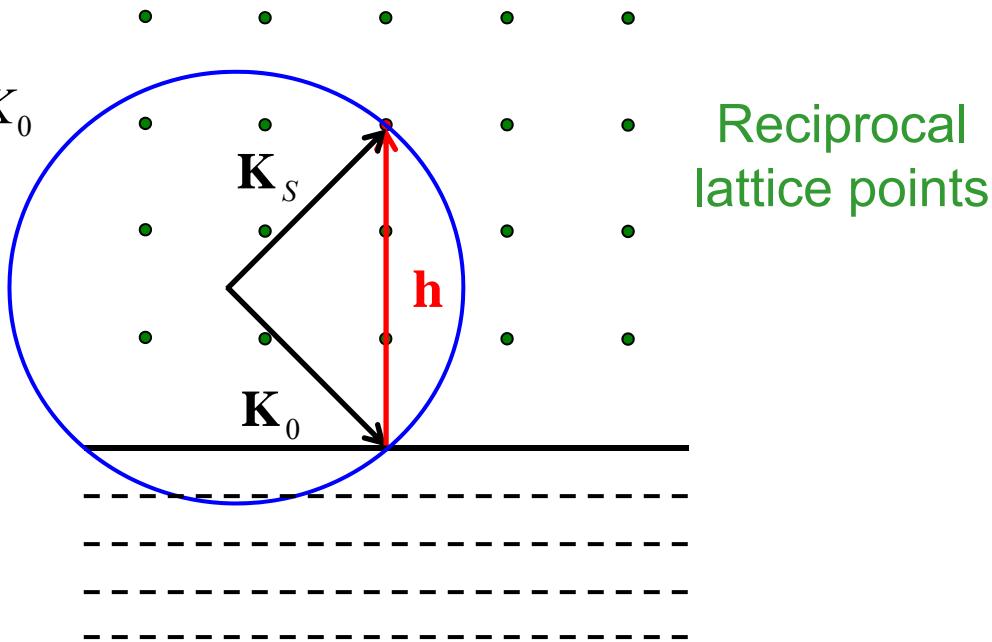
- Normal to net plane
- Length =  $1/d$



# Ewald sphere

Ewald sphere:

$$\text{Radius} = 1/\lambda = K_0$$

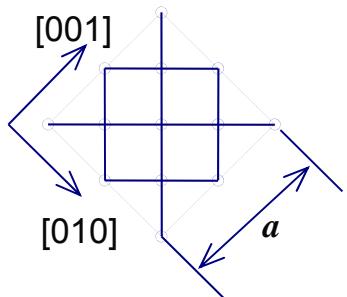


- When a reciprocal lattice point is on the Ewald sphere,  
Bragg reflection occurs.

# Miller indices and $d$ -spacing for silicon

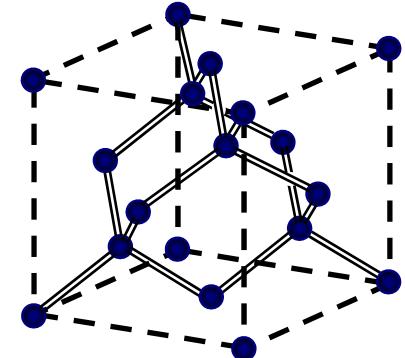
$$d = \frac{a}{\sqrt{h^2 + k^2 + l^2}}$$

**Top view**

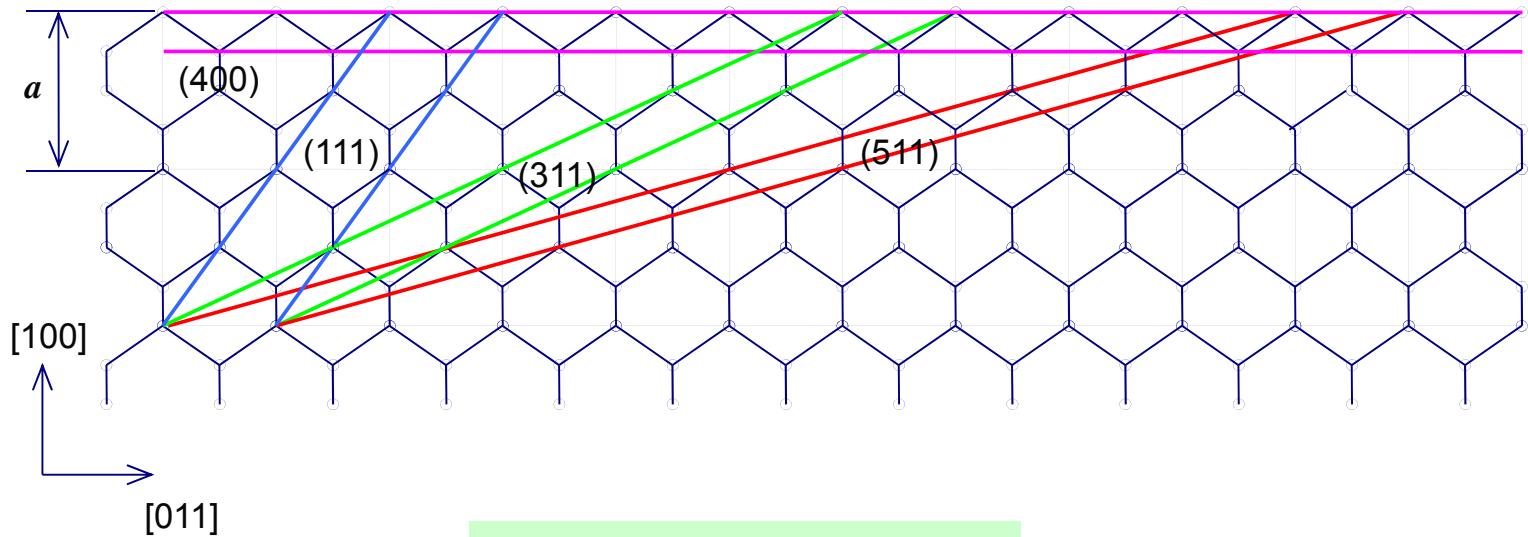


$$a = 5.431 \text{ \AA}$$

$d$ -spacing	(400) : 1.3578 \text{ \AA}
	(111) : 3.1356 \text{ \AA}
	(311) : 1.6375 \text{ \AA}
	(511) : 1.0452 \text{ \AA}



**Side view**



Diamond :  $a = 3.567 \text{ \AA}$

# Crystal structure factor for diamond structure

Structure factor → Sum of atomic scattering with phase shift in the unit cell

$$F(\mathbf{h}) = \sum_j f_j(\mathbf{h}, E) \exp(2\pi i \mathbf{h} \cdot \mathbf{r}_j)$$

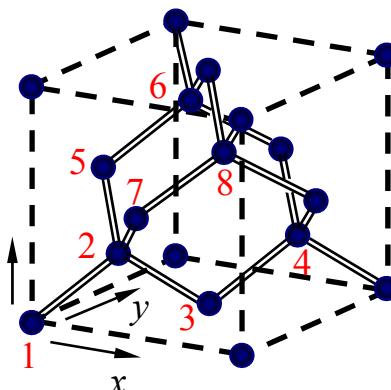
Atomic scattering factor

$$F(\mathbf{h}) = \sum_j f_j(\mathbf{h}, E) \exp\{2\pi i(hx_j + ky_j + lz_j)\}$$

For diamond structure

$\left\{ \begin{array}{l} h, k, l \text{ Mixture of odd and even numbers} \\ F = 0 \end{array} \right.$

$\left\{ \begin{array}{l} h, k, l \text{ All odd, or, all even numbers, and } m: \text{integer,} \\ h + k + l = 4m \quad F = 8f \quad \leftarrow 8 \text{ atoms in phase} \\ h + k + l = 4m \pm 1 \quad F = 4(1 \pm i)f \quad \leftarrow \text{Half contribute with phase shift } \pm \pi/2 \\ h + k + l = 4m \pm 2 \quad F = 0 \quad \leftarrow \text{Half cancel with } \pi \end{array} \right.$



Position of atoms in the unit cell for diamond structure

$$\begin{aligned} (x_j, y_j, z_j) = & (0, 0, 0)_1, (1/4, 1/4, 1/4)_2, \\ & (1/2, 1/2, 0)_3, (3/4, 3/4, 1/4)_4, \\ & (0, 1/2, 1/2)_5, (1/4, 3/4, 3/4)_6, \\ & (1/2, 0, 1/2)_7, (3/4, 1/4, 3/4)_8 \end{aligned}$$

# Crystal structure factor for diamond structure

(400), (220),...

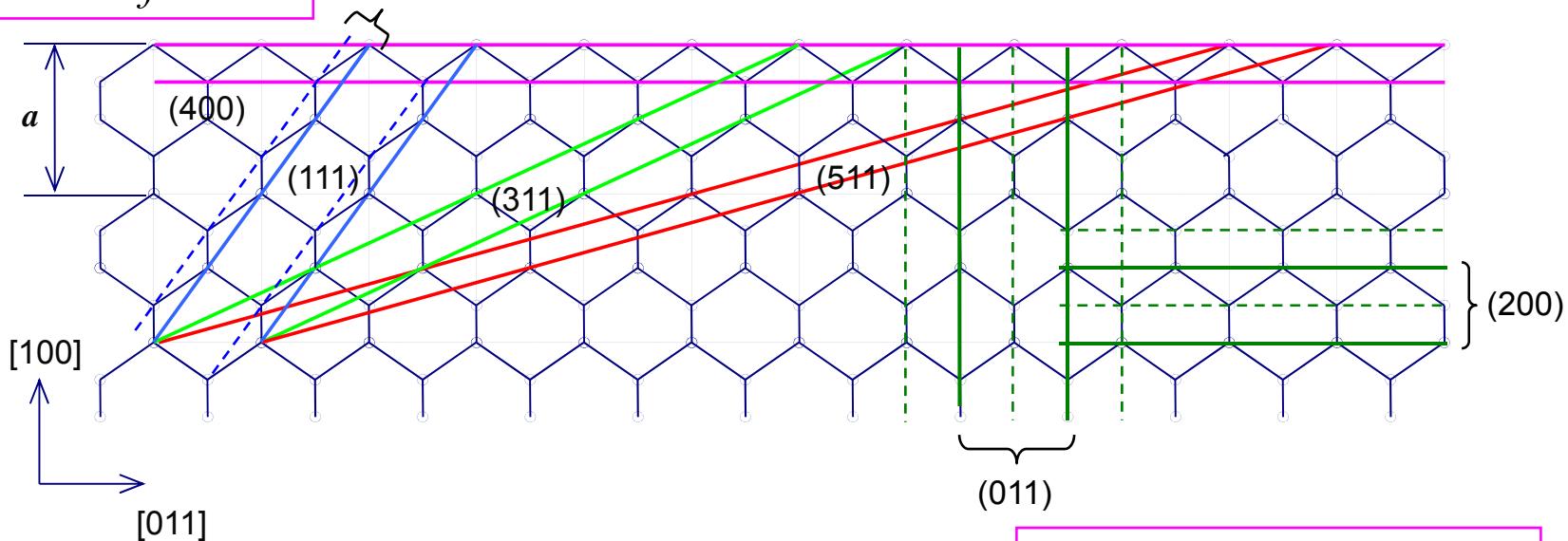
All in phase

$$\rightarrow F = 8f$$

(111), (311),...

Half contribute with phase shift  $\pm\pi/2$

$$\rightarrow F = 4(1 \pm i)f$$

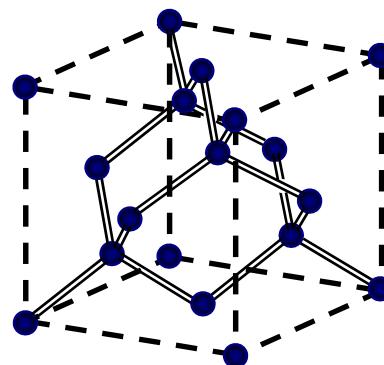


(011), (200),...

Half cancel with  $\pi$

$\rightarrow$  Forbidden reflection

$$F = 0$$



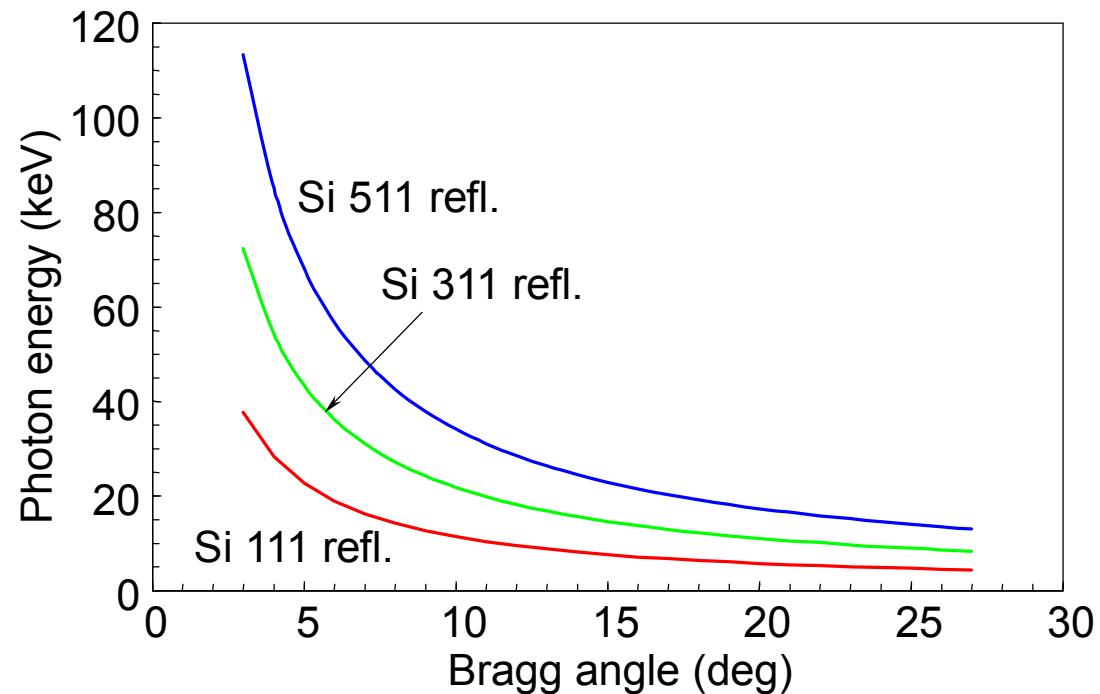
# X-ray monochromator using perfect crystal

→ Perfect single crystal: silicon, diamond,..

Photon energy tuning:

- Crystal & lattice plane
- Bragg angle range

$$E \text{ [keV]} = \frac{12.3984}{2d_{hkl} \text{ [\AA}} \sin \theta_B$$



e.g. for SPring-8 standard DCM

Bragg angle: 3~27°

# Kinematical X-ray diffraction

3-dimensional periodic structure of unit cell with number  $N_x, N_y, N_z$

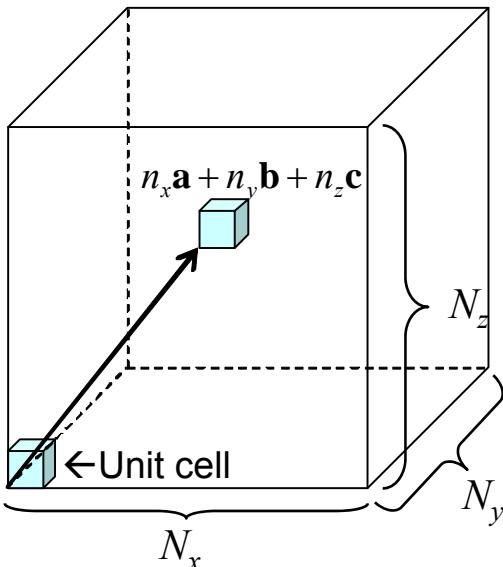
Total scattering intensity becomes:

$$I = I_e |F(\mathbf{Q})|^2 \cdot |G(\mathbf{Q})|^2$$

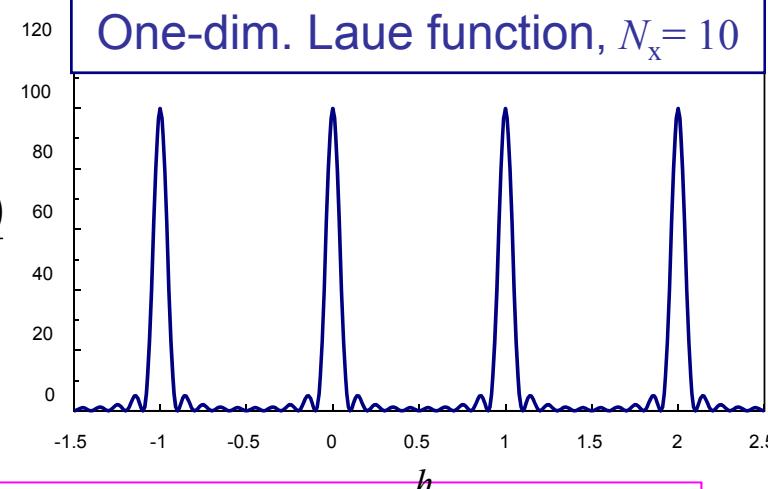
Laue function:  $|G(\mathbf{Q})|^2 = \frac{\sin^2(\pi N_x h)}{\sin^2(\pi h)} \cdot \frac{\sin^2(\pi N_y k)}{\sin^2(\pi k)} \cdot \frac{\sin^2(\pi N_z l)}{\sin^2(\pi l)}$

← 3-dim. Periodic structure

$h, k, l$ : integer → Intense peaks  
 →  $(hkl)$  reflection



$$\frac{\sin^2(\pi N_x h)}{\sin^2(\pi h)}$$



Peak intensity  $N_x^2$

FWHM  $\Delta h \approx 0.8858/N_x \sim 1/N_x$

Crystal size becomes larger → narrower & higher,  
 approaching delta function

# Dynamical theory

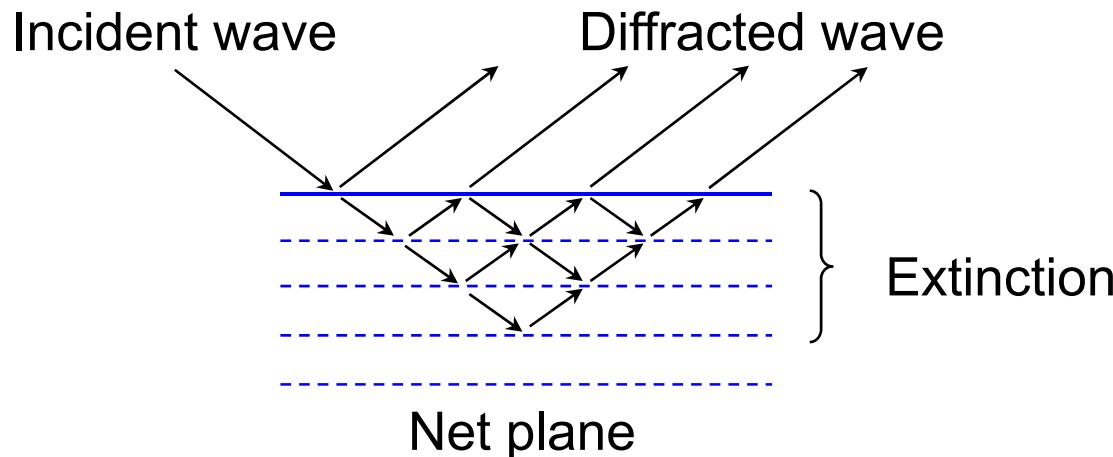
## *Two-beam approximation*

# Kinematical to dynamical theory

“Large & perfect” single crystal:

- 1) Multiple scattering w/  $\mathbf{h}$  &  $-\mathbf{h}$  reflection
- 2) Extinction  
(Diffraction by “finite” number of net planes)

Kinematical diffraction is invalid  
→ Dynamical theory must be applied.



# Fundamental equation

Fundamental equation is derived

using **Maxwell's equations** and introducing **Bloch wave**

for 3-dimensional periodic medium (= perfect single crystal):

$$\frac{k_h^2 - K_0^2}{K_0^2} E_h = \sum_g \chi_{h-g} (\mathbf{e}_h \cdot \mathbf{e}_g) E_g$$

$h, g, \dots$  : Reciprocal lattice points

$E_h, E_g$  : Fourier components of electric field

$K_0$  : Incident wave vector in vacuum

$\mathbf{k}_h$  : Wave vectors in the crystal

$\chi_h$  : Fourier components of the polarizability (Negative values,  $10^{-6} \sim 10^{-5}$ )

$P = (\mathbf{e}_h \cdot \mathbf{e}_g)$  : Polarization factor between  $h$  and  $g$  waves

$k_h = k_0 + h$  : Momentum conservation

# Two-beam approximation

Fundamental equation is reduced to the equation for  
**two beams (waves)** of incidence and “one” intense diffraction

$$\frac{k_h^2 - K_0^2}{K_0^2} E_h = \sum_g \chi_{h-g} (\mathbf{e}_h \cdot \mathbf{e}_g) E_g$$



$$(A) \frac{k_0^2 - K_0^2}{K_0^2} E_0 = \chi_0 E_0 + P \chi_{-h} E_h$$

$$(B) \frac{k_h^2 - K^2}{K^2} E_h = P \chi_h E_0 + \chi_0 E_h$$

$\chi_0, \chi_h, \chi_{-h}$  : Fourier components of the polarizability

(Negative values,  $10^{-6} \sim 10^{-5}$ )

$P = (\mathbf{e}_0 \cdot \mathbf{e}_h)$  : Polarization factor ( $\sigma : P = 1, \pi : P = \cos 2\theta_B$ )

# Two-beam approximation

Using two equations, we obtain following secular equation:

$$(A) \frac{k_0^2 - K_0^2}{K_0^2} E_0 = \underline{\chi_0 E_0} + \underline{P \chi_{-h} E_h}$$

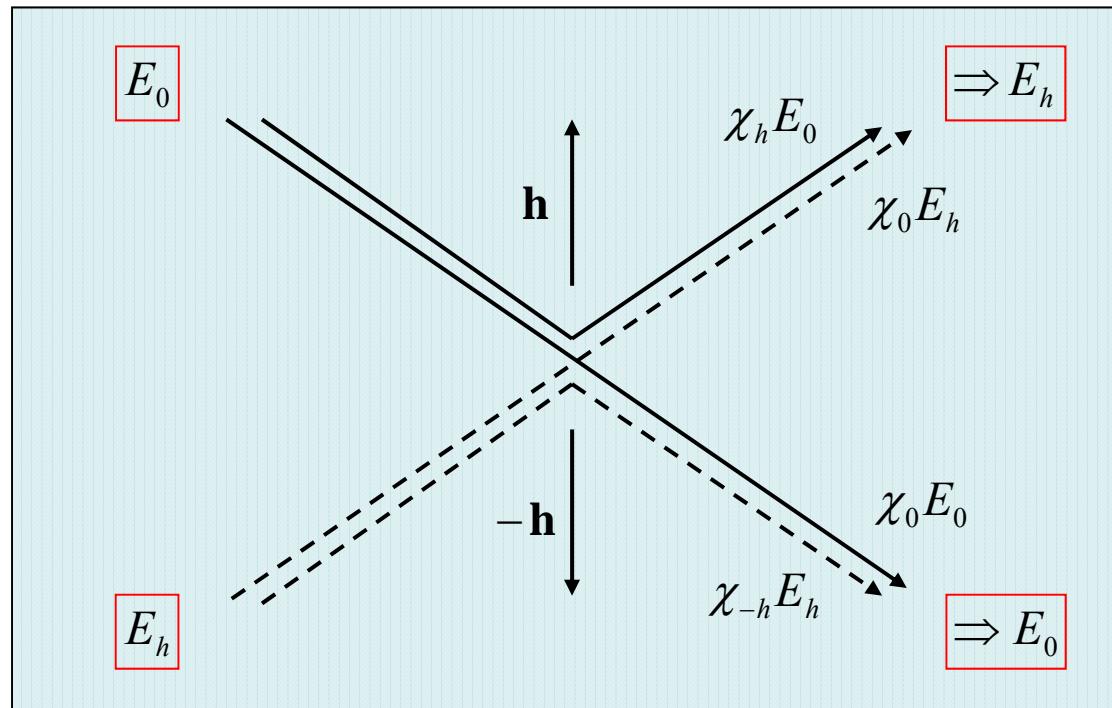
$$(B) \frac{k_h^2 - K^2}{K^2} E_h = \underline{P \chi_h E_0} + \underline{\chi_0 E_h}$$

Secular equation

$$(\mathbf{k}_0^2 - k^2)(\mathbf{k}_h^2 - k^2) = \underline{\chi_h \chi_{-h}} P^2 K_0^4$$

$$k^2 = (1 + \chi_0) K_0^2$$

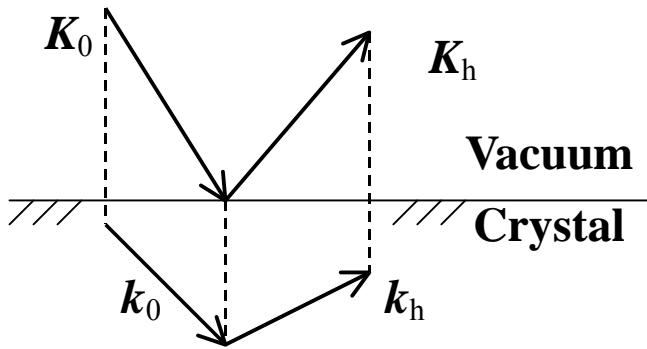
$k$  : Mean wave number in the crystal



Scheme of self-consistent wave field

# Boundary condition of wave vector

We must consider connections of waves from vacuum into the crystal and from the crystal to vacuum, to solve the equations.

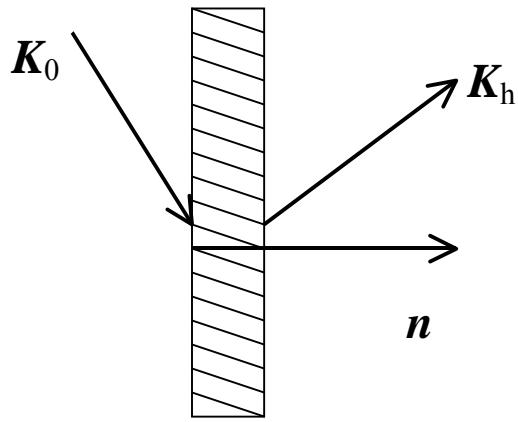


**Tangential component of wave vector must be continuous.**

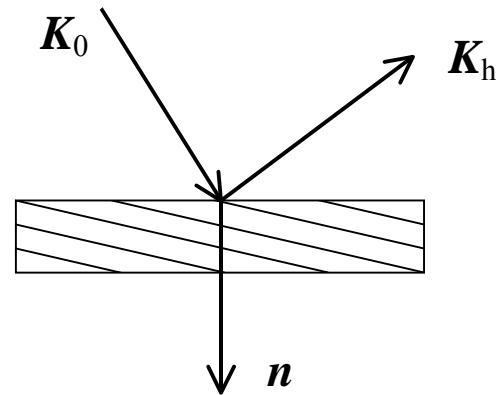
Incident wave in vacuum

- Refracted wave in the crystal
- Bragg reflection in the crystal
- Reflected wave in the crystal
- Reflected wave in vacuum

# Laue case and Bragg case



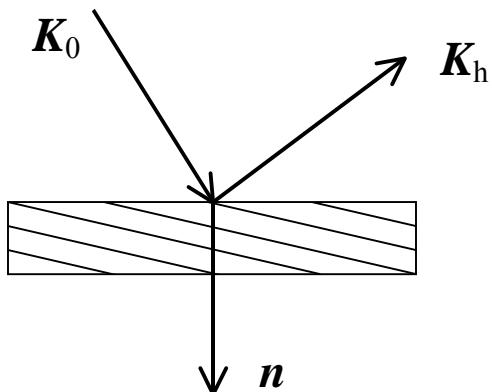
**Laue case**  
(Transmission geometry)



**Bragg case**  
(Reflection geometry)

# Asymmetry ratio

$$\left\{ \begin{array}{l} \gamma_0 = \hat{K}_0 \cdot n \\ \gamma_h = \hat{K}_h \cdot n \end{array} \right. \quad b = \frac{\gamma_0}{\gamma_h}$$



**Laue case:  $b > 0$**

Symmetric Laue case:  $b = 1$

**Bragg case:  $b < 0$**

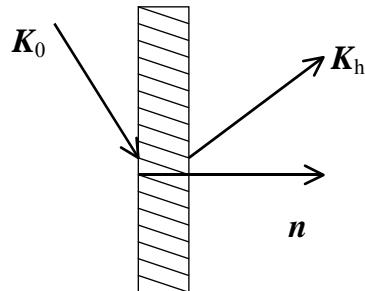
Symmetric Bragg case:  $b = -1$

**n:** normal vector to the surface

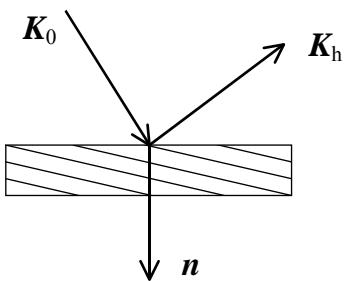
# Dispersion surface

$$(\mathbf{k}_0^2 - k^2)(\mathbf{k}_h^2 - k^2) = \chi_h \chi_{-h} P^2 K_0^4$$

← Secular equation is **quartic** equation, and it gives four-point solution on the  **$n$** -vector, producing the **dispersion surfaces**.

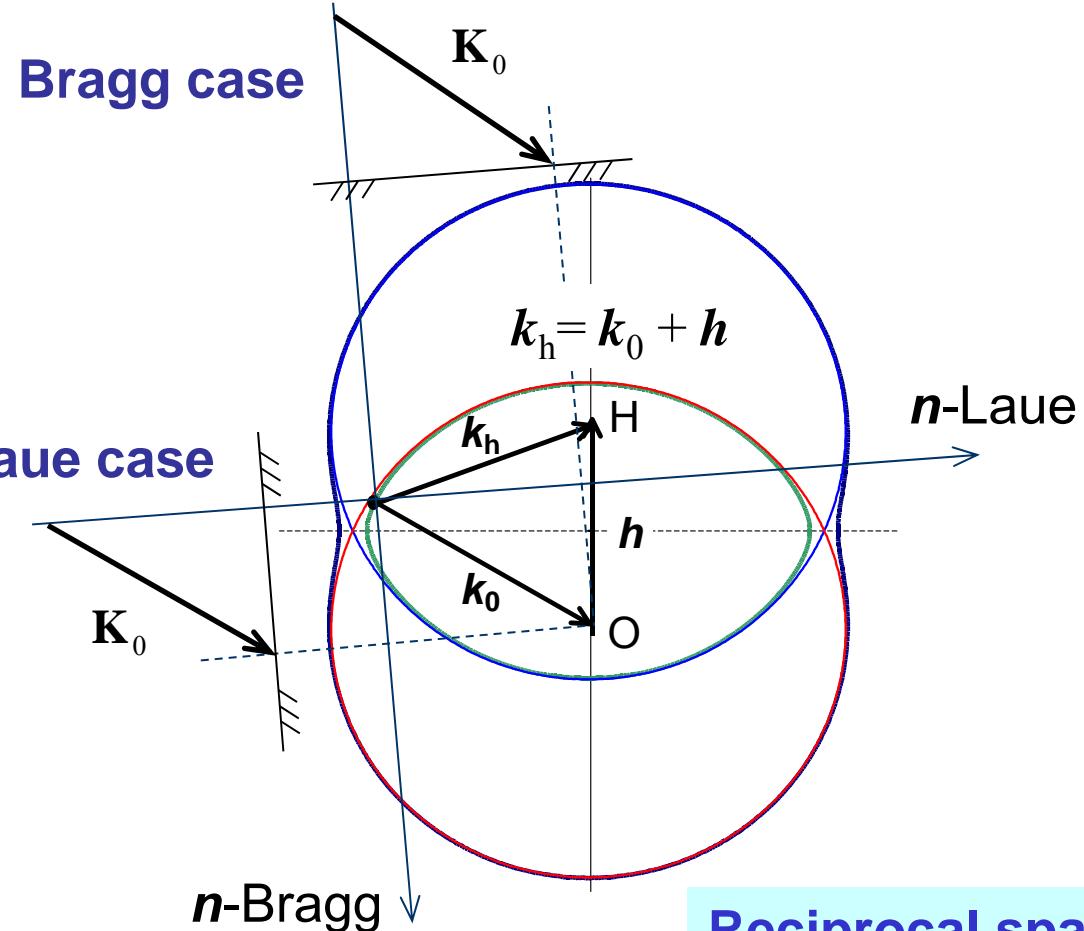


Laue case



Bragg case

Real space



Two dispersion surfaces show the gap near Bragg condition.

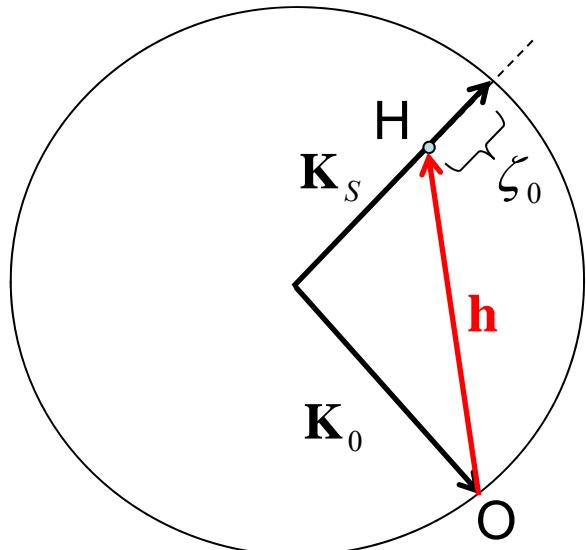
# Deviation from Bragg condition

## Excitation error

→ Geometrical deviation  $\zeta_0$  from Bragg condition:

Distance between Ewald sphere and the reciprocal lattice point.

$\zeta_0$  is positive when H is inside the Ewald sphere (by S. Miyake).

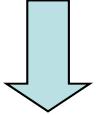


$$\zeta_0 \approx -\frac{2(\mathbf{K}_0 \cdot \mathbf{h}) + h^2}{2K_0}$$

# Normalized deviation parameter $W$

Parameter  $W$  is related to the gap between two dispersion surfaces and total reflection occurs at  $-1 < W < 1$  for Bragg case.

$$W = -\frac{2(\mathbf{K}_0 \cdot \mathbf{h}) + h^2}{2K_0^2} \sqrt{\frac{\gamma_0}{|\gamma_h|}} \frac{1}{|\chi_{hr}| \cdot |P|} + \frac{\chi_{0r}}{2|\chi_{hr}| \cdot |P|} \sqrt{\frac{\gamma_0}{|\gamma_h|}} \left(1 - \frac{\gamma_h}{\gamma_0}\right)$$

$\zeta_0$  

$\Delta\theta$ : Angle deviation for fixed photon energy,

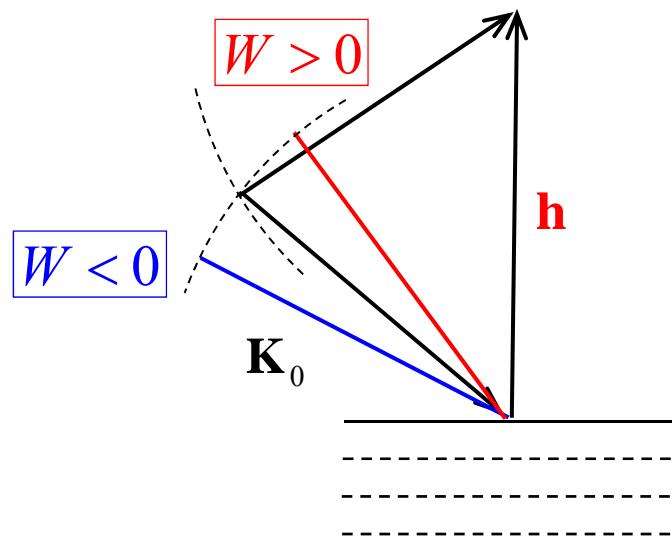
$\Delta E$ : Energy deviation for fixed incident angle

$$W = \left\{ \Delta\theta \sin 2\bar{\theta}_{BK} + 2 \frac{\Delta E}{E} \sin^2 \bar{\theta}_{BK} + \frac{\chi_{0r}}{2} \left(1 - \frac{\gamma_h}{\gamma_0}\right) \right\} \sqrt{\frac{\gamma_0}{|\gamma_h|}} \frac{1}{|\chi_{hr}| \cdot |P|}$$

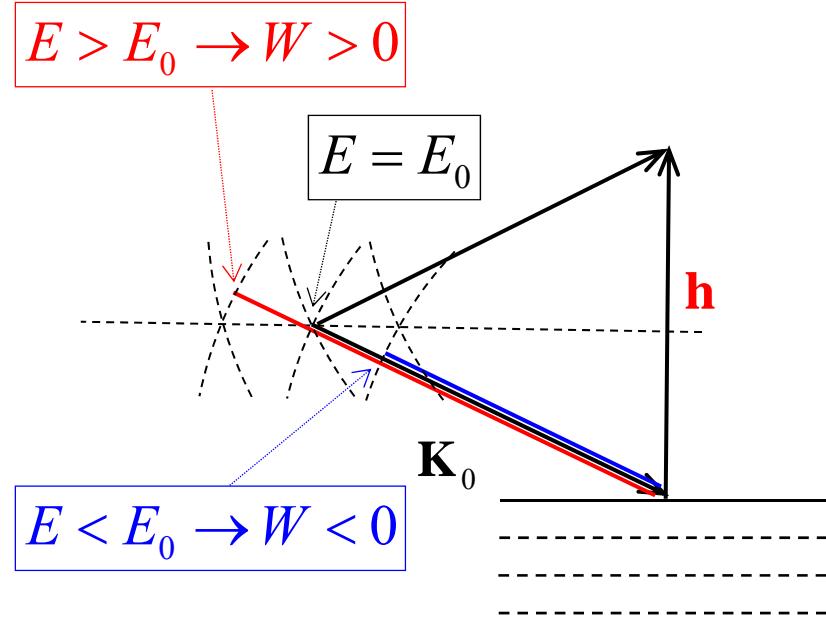
For symmetric Bragg case, sigma polarization:  
28

$$W = \left\{ \Delta\theta \sin 2\bar{\theta}_{BK} + 2 \frac{\Delta E}{E} \sin^2 \bar{\theta}_{BK} + \chi_{0r} \right\} \frac{1}{|\chi_{hr}|}$$

# Sign of deviation parameter $W$



Angle deviation at fixed energy  
→ direction change of wave vector



Energy deviation at fixed angle  
→ length change of wave vector

# Movement of tie point

Tie point moves by changing the incident angle

at fixed photon energy (wavelength).

(1) Lower angle

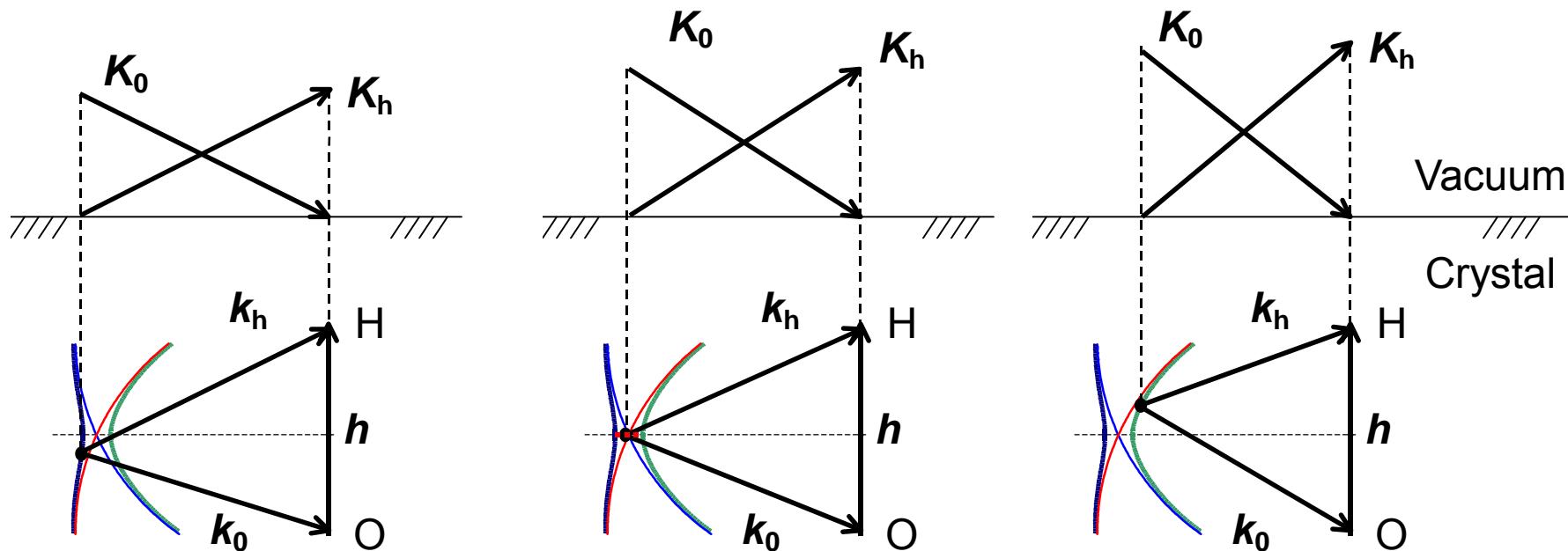
$$W < -1$$

(2) Near Bragg condition

$$-1 < W < 1$$

(3) Higher angle

$$W > 1$$



Total reflection

Dominant branch for thick Bragg-case crystal is close to O-sphere.

# Calculation of polarizability

$\chi_h$ : Fourier component of polarizability  
 → proportional to the structure factor

$$\chi_h = -\frac{r_e \lambda^2}{\pi v_c} F(\mathbf{h}, E)$$

$v_c$ : unit cell volume

$$\chi_h = \chi_{hr} + \chi_{hi}$$

$$\chi_{hr} \Leftrightarrow f^0(\mathbf{h}) + f'(E)$$

Atomic form factor  
 + real part of anomalous factor

$$\chi_{hi} \Leftrightarrow f''(E)$$

Imaginary part of  
 anomalous factor

For diamond structure

$$h + k + l = 4m$$

$$\chi_{hr} = -\frac{r_e \lambda^2}{\pi v_c} 8(f^0 + f')e^{-M}$$

$$\chi_{hi} = -\frac{r_e \lambda^2}{\pi v_c} 8f''e^{-M}$$

$$h + k + l = 4m \pm 1$$

$$\chi_{hr} = -\frac{r_e \lambda^2}{\pi v_c} 4(1+i)(f^0 + f')e^{-M}$$

$$\chi_{hi} = -\frac{r_e \lambda^2}{\pi v_c} 4(1+i)f''e^{-M}$$

$$h = k = l = 0$$

$$\chi_{0r} = -\frac{r_e \lambda^2}{\pi v_c} 8(Z + f')$$

$$\chi_{0i} = -\frac{r_e \lambda^2}{\pi v_c} 8f''$$

# Amplitude ratio

From the solution of the fundamental equations,  
we obtain the ratio  $r = E_h/E_0$  ( $\leftarrow$  reflection coefficient)  
as a function of parameter  $W$ .

For Bragg case, no absorption, and thick crystal:

$$\left\{ \begin{array}{l} r = \frac{E_h}{E_0} = -\sqrt{\frac{\gamma_0}{|\gamma_h|}} \frac{|\chi_{hr}|}{\chi_{-h}} \frac{|P|}{P} (W + \sqrt{W^2 - 1}) \quad (W < -1) \\ \\ r = \frac{E_h}{E_0} = -\sqrt{\frac{\gamma_0}{|\gamma_h|}} \frac{|\chi_{hr}|}{\chi_{-h}} \frac{|P|}{P} (W + i\sqrt{1 - W^2}) \quad (-1 \leq W \leq 1) \quad \leftarrow \text{Total reflection} \\ \\ r = \frac{E_h}{E_0} = -\sqrt{\frac{\gamma_0}{|\gamma_h|}} \frac{|\chi_{hr}|}{\chi_{-h}} \frac{|P|}{P} (W - \sqrt{W^2 - 1}) \quad (W > 1) \end{array} \right.$$

# Reflectivity (Darwin curve)

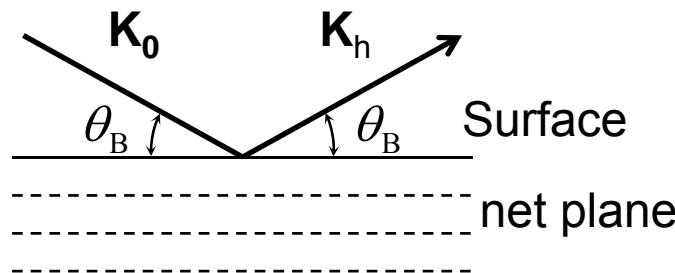
Darwin curve (intrinsic reflection curve for monochromatic plane wave)  
for Bragg case, no absorption, and thick crystal:

$$\begin{cases} R = \left( W + \sqrt{W^2 - 1} \right)^2 & (W < -1) \\ R = 1 & (-1 \leq W \leq 1) \quad \leftarrow \text{Total reflection region} \\ R = \left( W - \sqrt{W^2 - 1} \right)^2 & (W > 1) \end{cases}$$

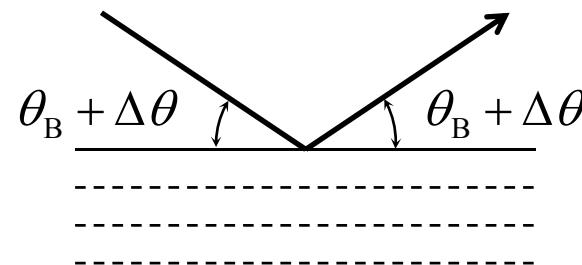
$W$ : deviation parameter for s-polarization, symmetrical Bragg case

$$W = \left( \Delta\theta \sin 2\theta_B + 2 \sin^2 \theta_B \frac{\Delta E}{E} + \chi_0 \right) \frac{1}{|\chi_h|}$$

Angular deviation  
Energy deviation  
Refraction

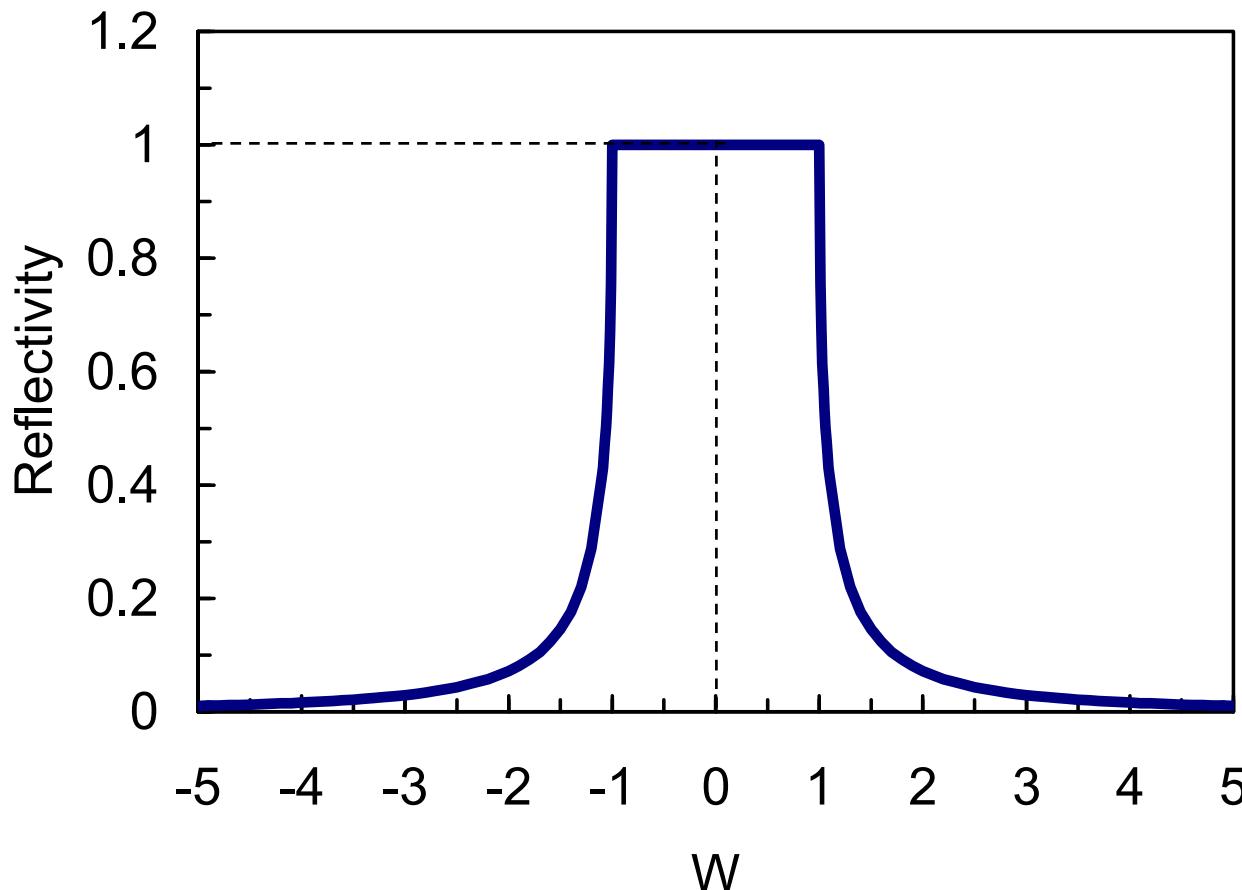


Geometry for  
symmetrical  
Bragg case



# Darwin curve

For Bragg case, **no absorption**, and thick crystal:



# Reflectivity with absorption

## Reflectivity

- symmetrical Bragg case,
- s-polarization,
- thick crystal

$$R = L - \sqrt{L^2 - 1}$$

$$L = \frac{\left\{ W^2 + g^2 + \sqrt{(W^2 - g^2 - 1 + \kappa^2)^2 + 4(gW - \kappa)^2} \right\}}{1 + \kappa^2}$$

$$W = \left( \Delta\theta \sin 2\bar{\theta}_{\text{B}} + 2 \sin^2 \bar{\theta}_{\text{B}} \frac{\Delta E}{E} + \chi_{0r} \right) \frac{1}{|\chi_{hr}|}$$

$$g = \frac{\chi_{0i}}{|\chi_{hr}|}, \quad \kappa = \frac{|\chi_{hi}|}{|\chi_{hr}|}$$

Note: No absorption  $g = 0, \kappa = 0 \Rightarrow R \rightarrow \text{Darwin curve}$

# Reflectivity curve for silicon

Examples for symmetrical Bragg case, **with absorption**,  
s-polarization and thick crystal:

Si 111 refl., 10 keV

$$\chi_{0r} = -9.78 \times 10^{-6}$$

$$\chi_{0i} = -1.48 \times 10^{-7}$$

$$\chi_{111\_r} = -3.66 \times 10^{-6} (1+i)$$

$$\chi_{111\_i} = -7.30 \times 10^{-8} (1+i)$$

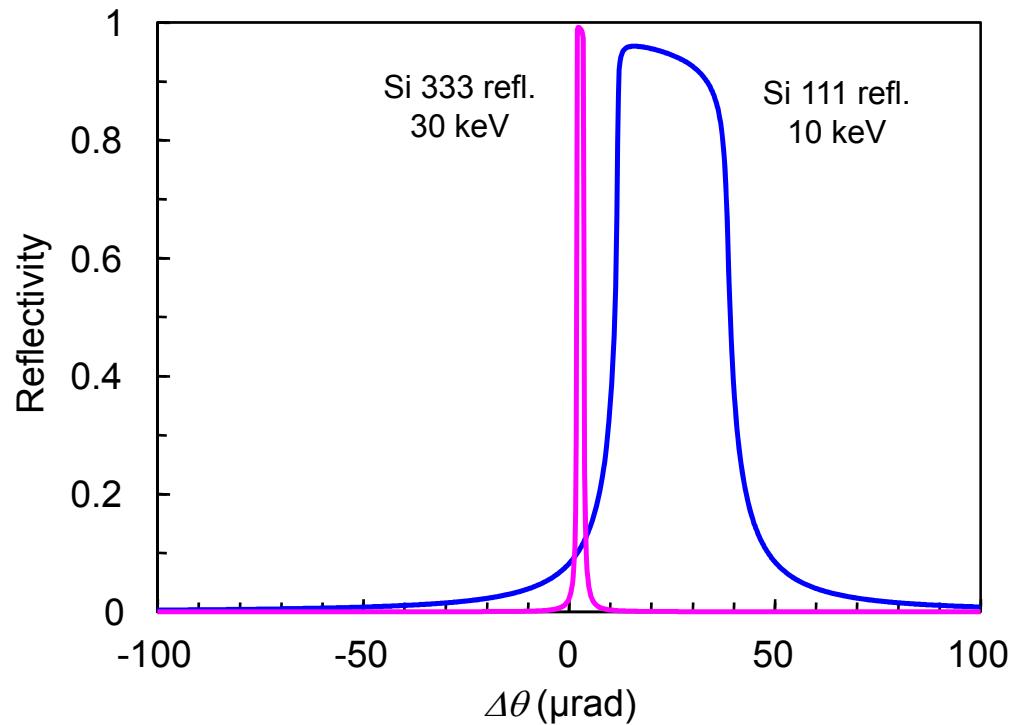
Si 333 refl., 30 keV

$$\chi_{0r} = -1.07 \times 10^{-6}$$

$$\chi_{0i} = -1.75 \times 10^{-9}$$

$$\chi_{333\_r} = -2.24 \times 10^{-7} (1+i)$$

$$\chi_{333\_i} = -7.87 \times 10^{-10} (1+i)$$



- Width of  $0.1 \sim 100$  μrad
- Peak  $\sim 1$  with small absorption

# DuMond (angle-energy) diagram

The diagram helps to understand how we can extract x-rays from SR source.

Angular width  
(Darwin width)

$$\Delta\theta_{\text{Darwin}} = \frac{2|\chi_{hr}|}{\sin 2\theta_B} \propto |F(\mathbf{h})| \quad \leftarrow \Delta W = 2$$

Energy resolution

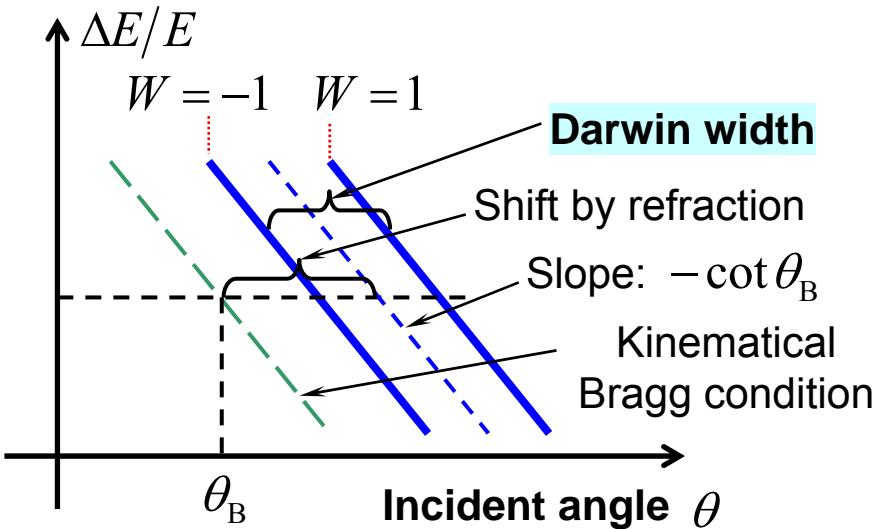
$$\frac{\Delta E}{E} = \cot \theta_B \sqrt{\Omega^2 + \Delta\theta_{\text{Darwin}}^2}$$

$\leftarrow$  Gaussian approximation for both light source and reflection curve

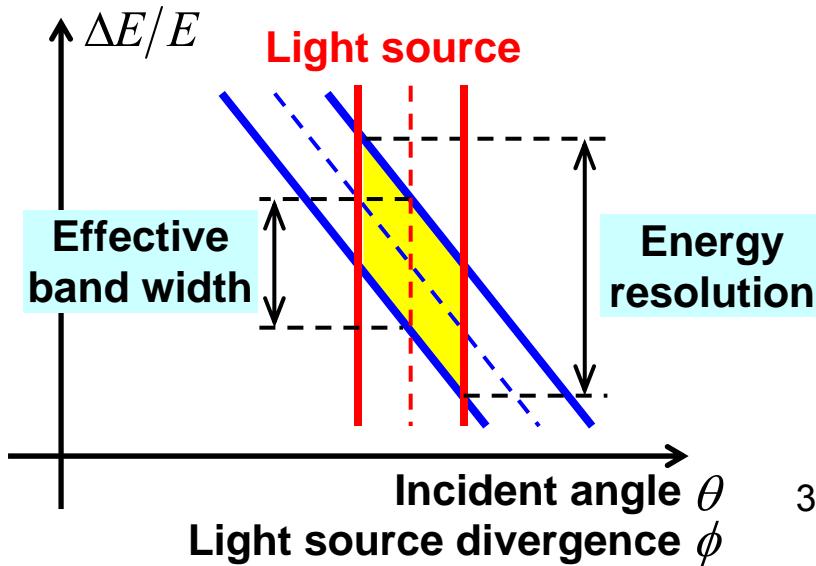
Effective band width

$$\frac{\Delta E}{E} \approx \frac{|\chi_{hr}|}{\sin^2 \theta_B}$$

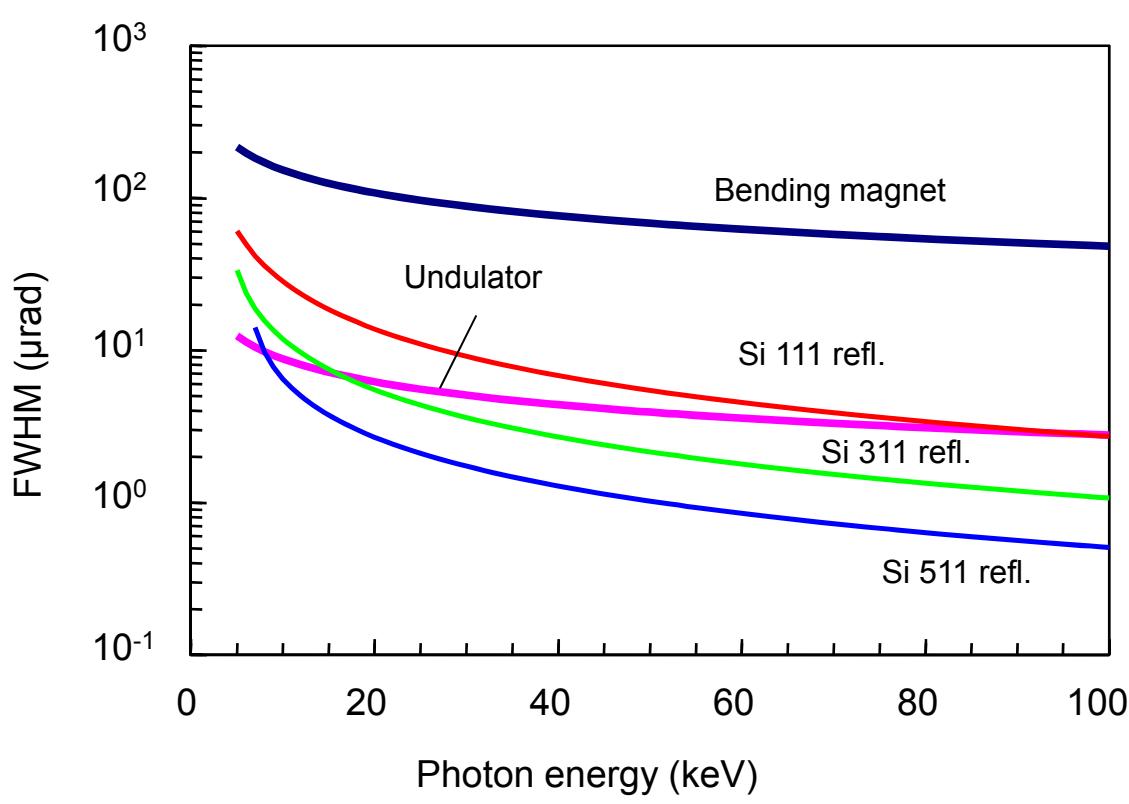
Relative energy



Relative energy



# Source divergence and diffraction width



Natural divergence

- Bending magnet

$$\sigma_{r'} \approx 0.597 \frac{1}{\gamma} \sqrt{\frac{\lambda}{\lambda_c}} \propto \sqrt{\frac{1}{\hbar\omega}}$$

- Undulator

$$\sigma_{r'} \approx \sqrt{\frac{\lambda}{2N\lambda_u}} \propto \sqrt{\frac{1}{\hbar\omega}}$$

For SPring-8 case:

- Bending magnet

$$\sigma_{r'} \approx 60 \mu\text{rad}$$

- Undulator ( $N= 140$ )

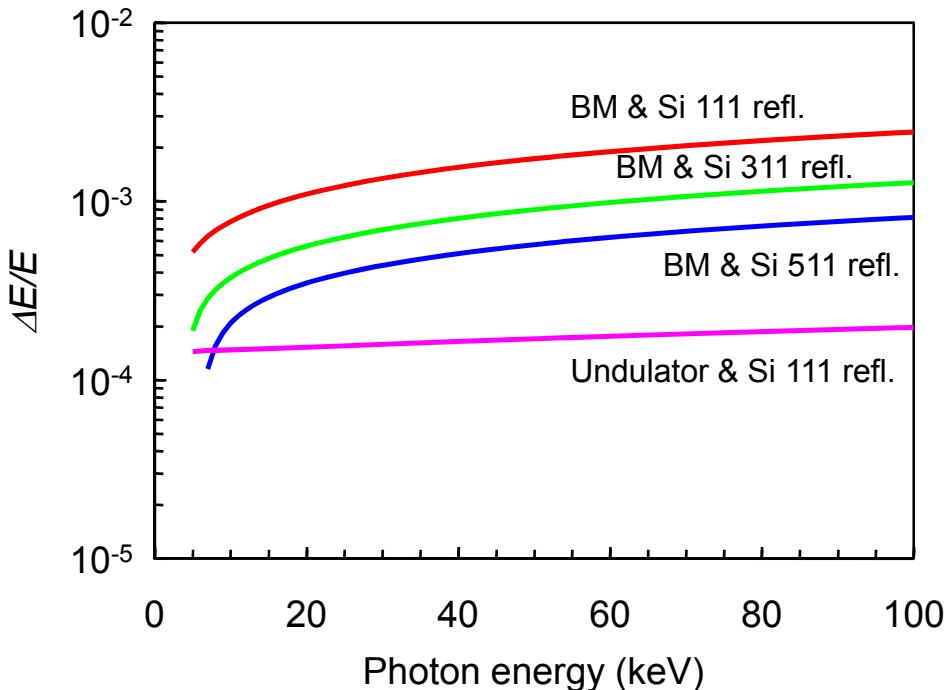
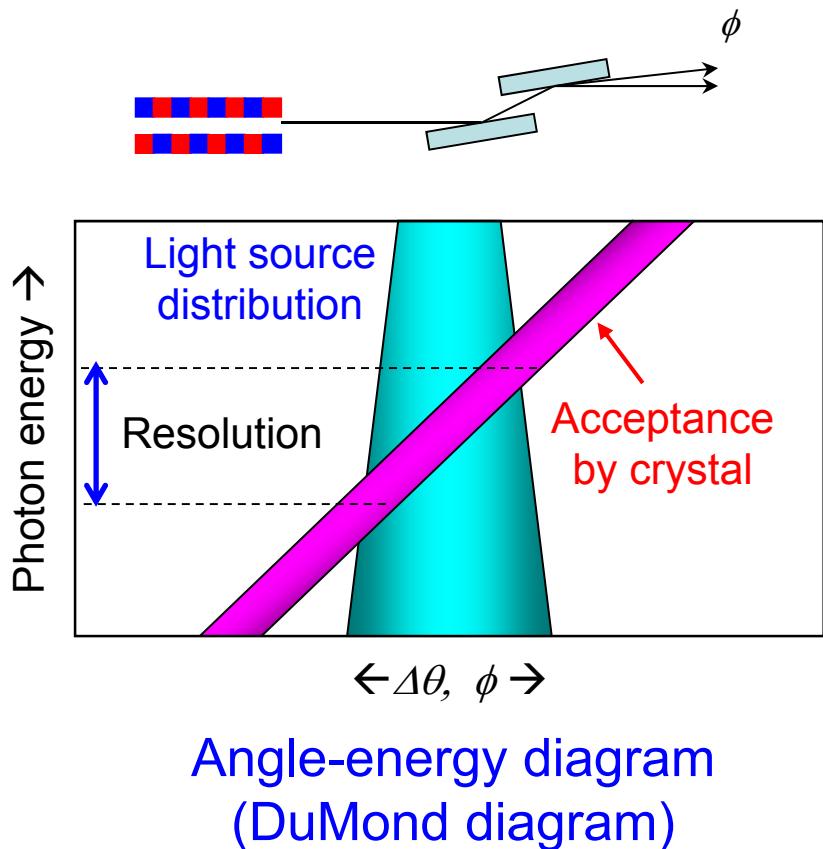
$$\sigma_{r'} \approx 5 \mu\text{rad}$$

Divergence of undulator radiation  $\sim$  diffraction width

# Energy resolution

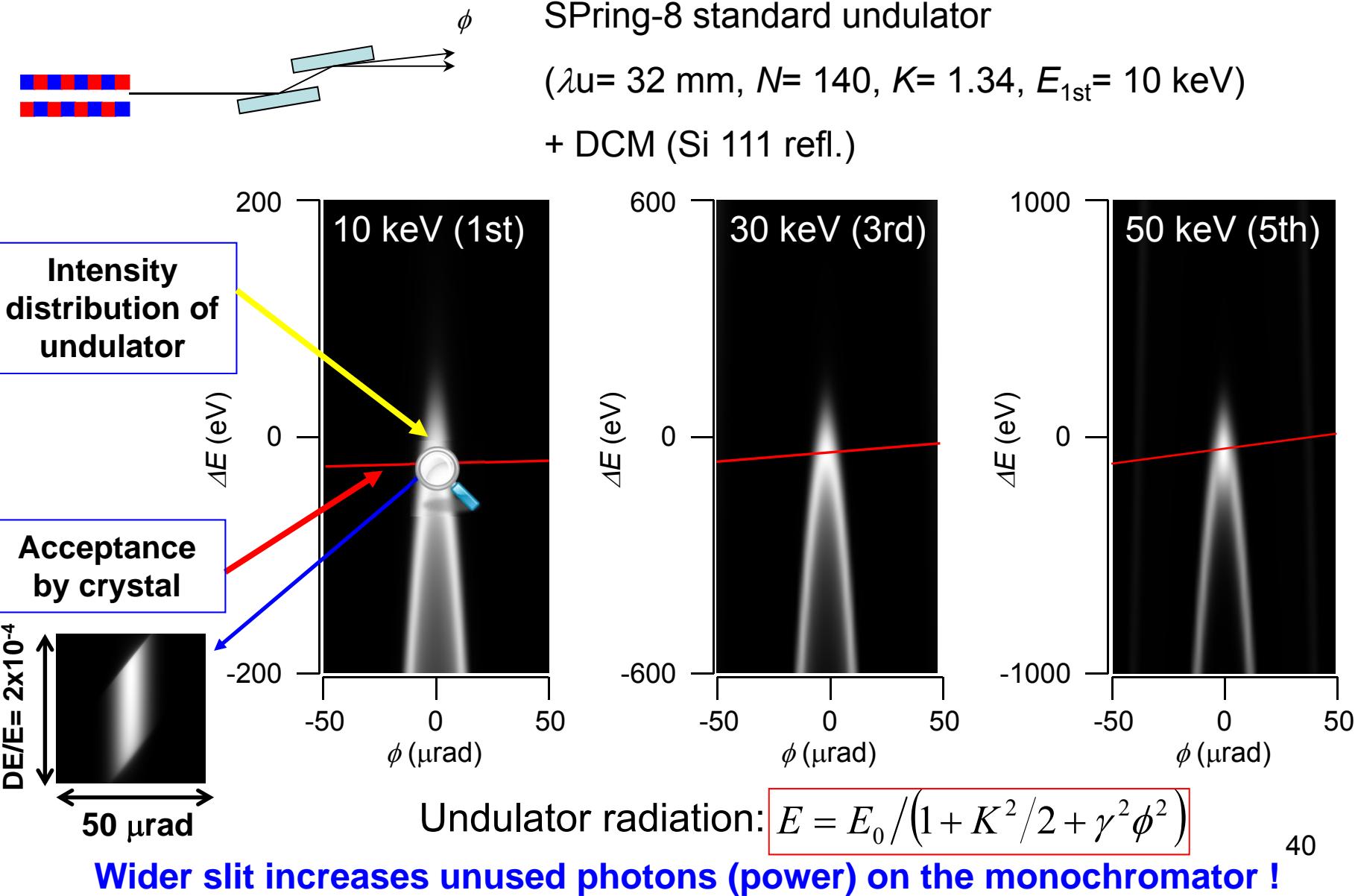
$$\frac{\Delta E}{E} = \cot \theta_B \sqrt{\Omega^2 + \omega^2}$$

$\Omega$ : source divergence,  
 $\omega$ : diffraction width



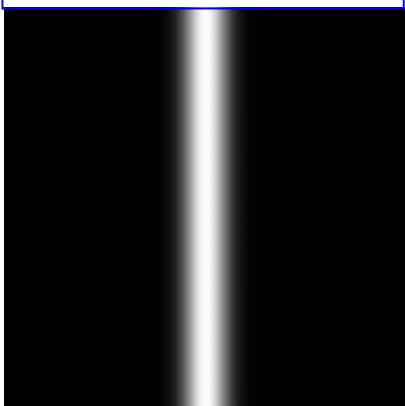
For usual beamline :  $\Delta E/E = 10^{-5} \sim 10^{-3}$

# DuMond diagram: undulator & DCM

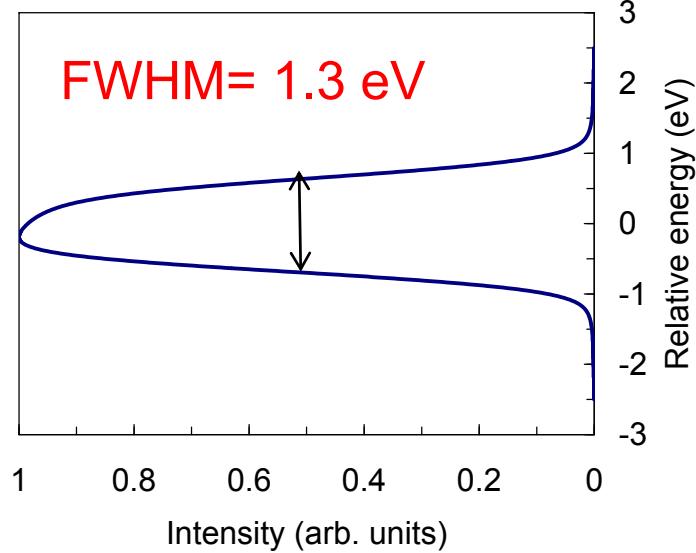
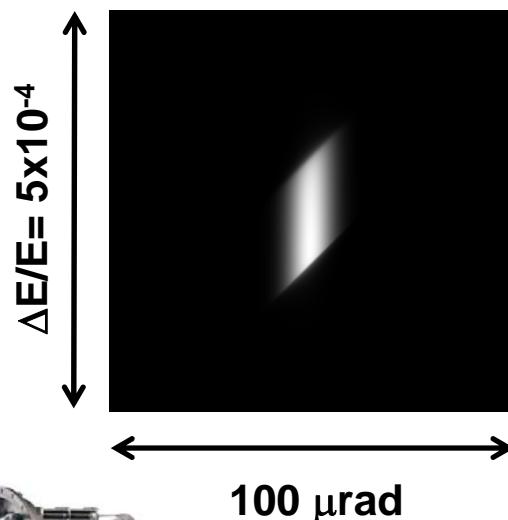
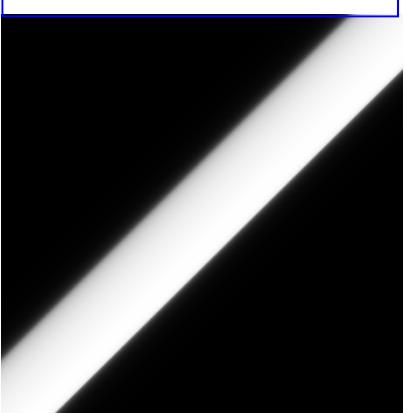


# DuMond diagram: undulator & DCM

Undulator radiation



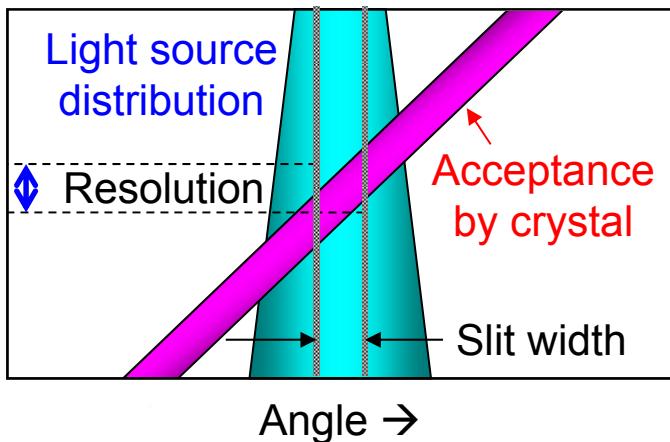
Acceptance by  
Si 111 DCM



SPring-8 standard undulator +  $20 \mu\text{rad}$  slit + Si 111 DCM  
10-keV photons  $\rightarrow 1.3 \times 10^{-4}$

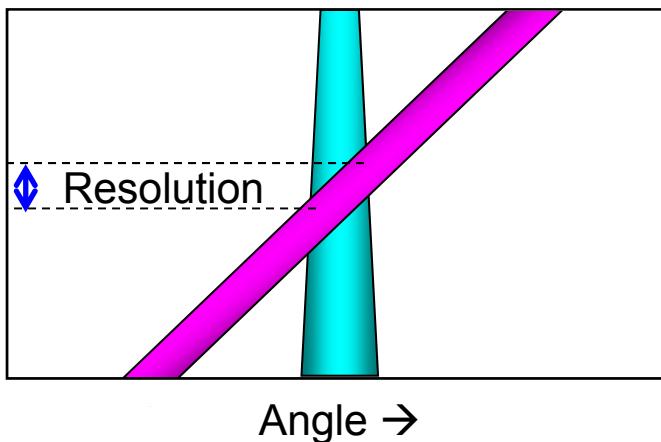
# Improvement of energy resolution

Photon energy →



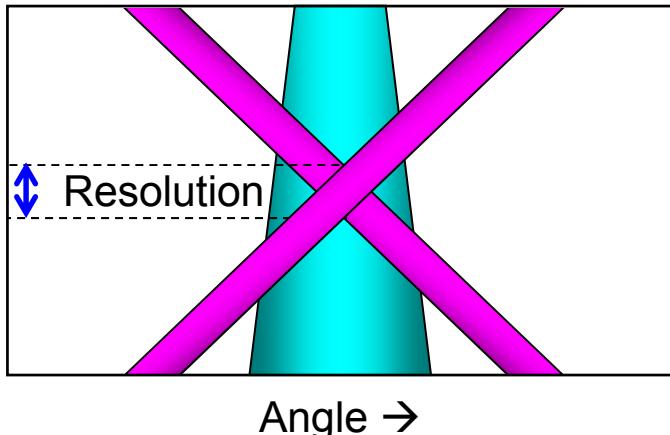
(A) Collimation using slit

Photon energy →



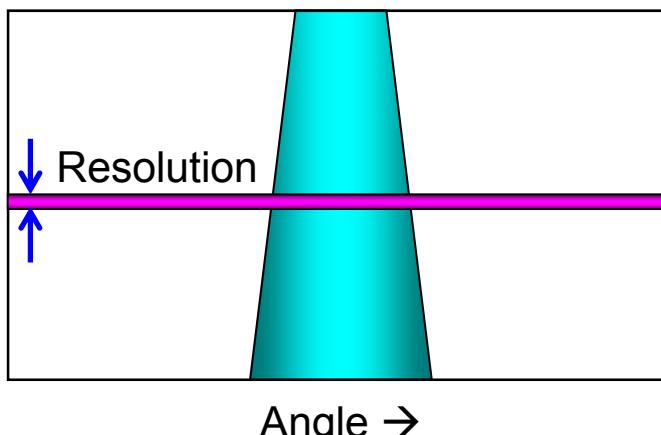
(B) Collimation using pre-optics  
w/ collimation mirror, CRL,..

Photon energy →



(C) Additional crystal  
w/  $(+,+)$  setting

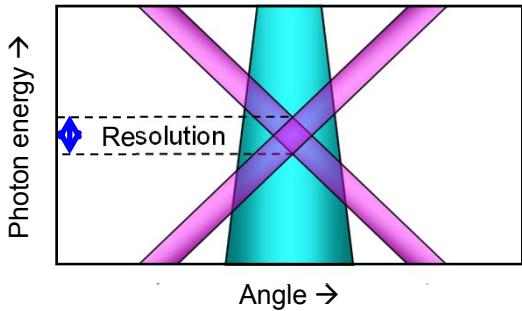
Photon energy →



(D) HR monochromator of  
 $\pi/2$  reflection (~meV)

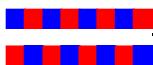
(B)~(D): restriction on photon energy

# Improvement of energy resolution



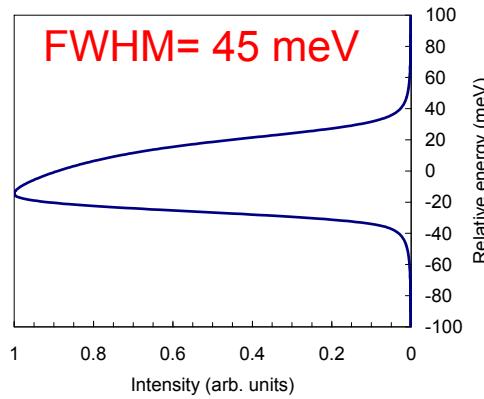
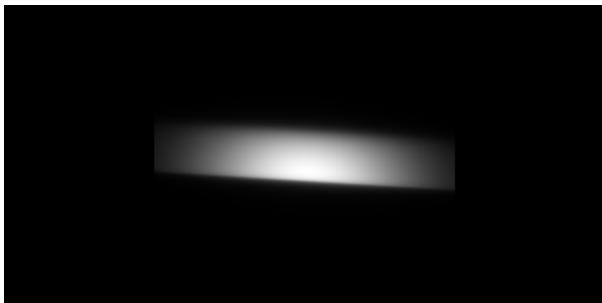
(C) Additional crystal w/ (+,+) setting  
→ HXPES

Si 111 DCM

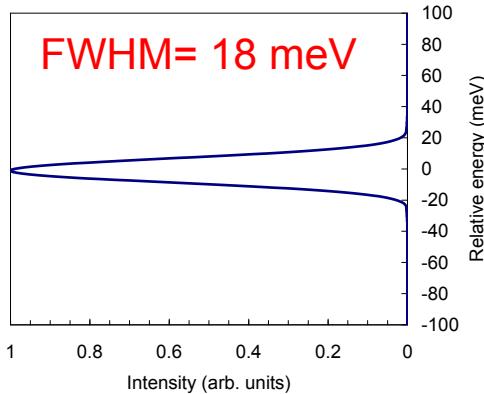
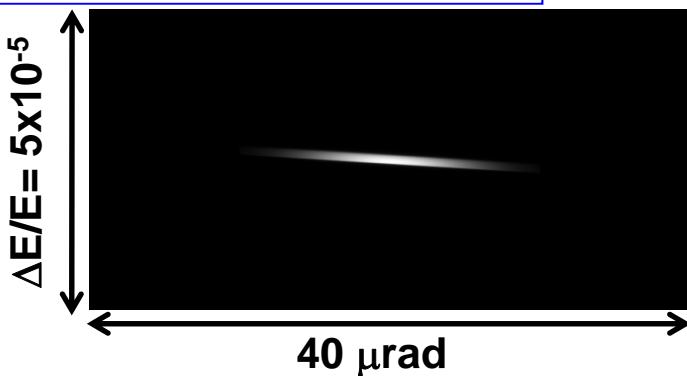


Si *nnn* channel-cut mono.

Si 333 refl. for 6 keV

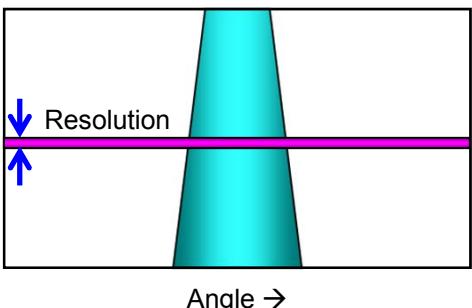


Si 555 refl. for 10 keV



# Improvement of energy resolution

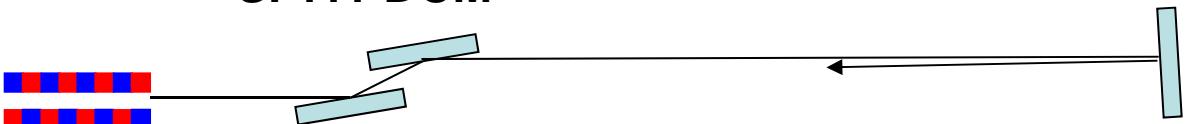
Photon energy →



(D) HR monochromator of  $\sim\pi/2$  reflection ( $\sim$ meV)

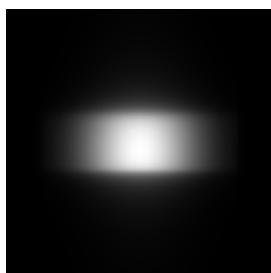
→ Inelastic scattering

Si 111 DCM

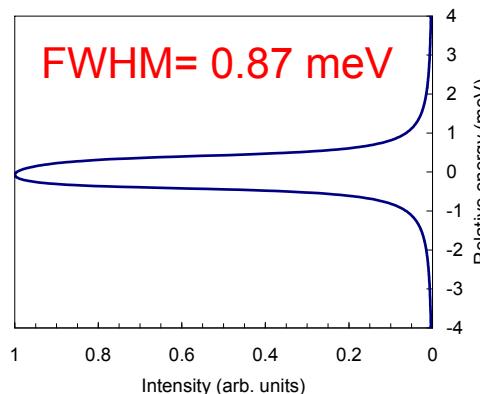
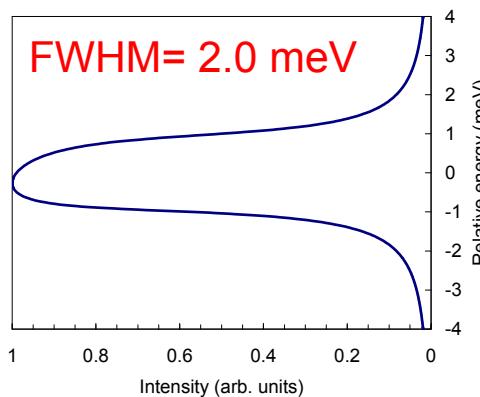
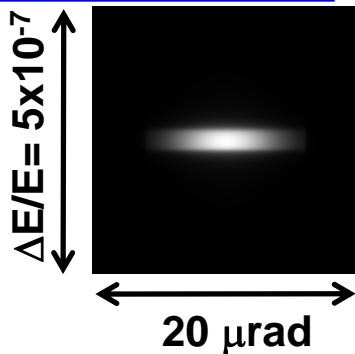


Si *nnn* back-scattering mono.

Si 999 refl. for 17.8 keV



Si 11 11 11 refl. for 21.7 keV



# Photon flux after monochromator

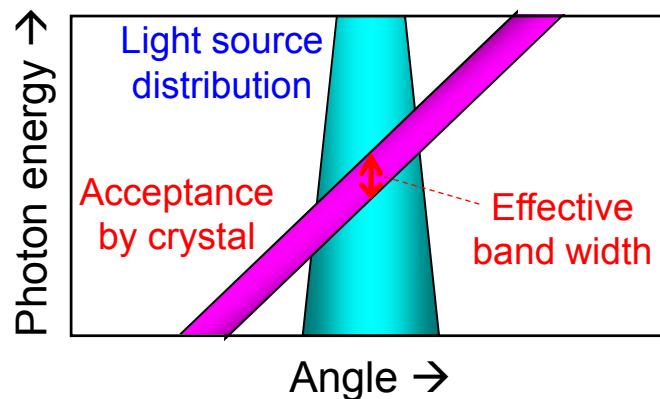
Photon flux (throughput) after monochromator can be estimated using effective band width:

**Photon flux (ph/s) =**

**Photon flux from light source (ph/s/0.1%bw)**

**x 1000**

**x Effective band width of monochromator**



Throughput is estimated by overlapped area.

Note difference from energy resolution.

# Effective band width

Starting with Darwin width in the energy axis

$$\frac{\Delta E}{E} \approx \frac{|\chi_{hr}|}{\sin^2 \theta_B}$$

$$\chi_{hr} \propto \lambda^2 \left\{ f^0(d_{hkl}) + f'(\lambda) \right\}$$

Neglecting anomalous scattering factor  $f'$

$$\chi_{hr} \propto \lambda^2 f^0(d_{hkl})$$

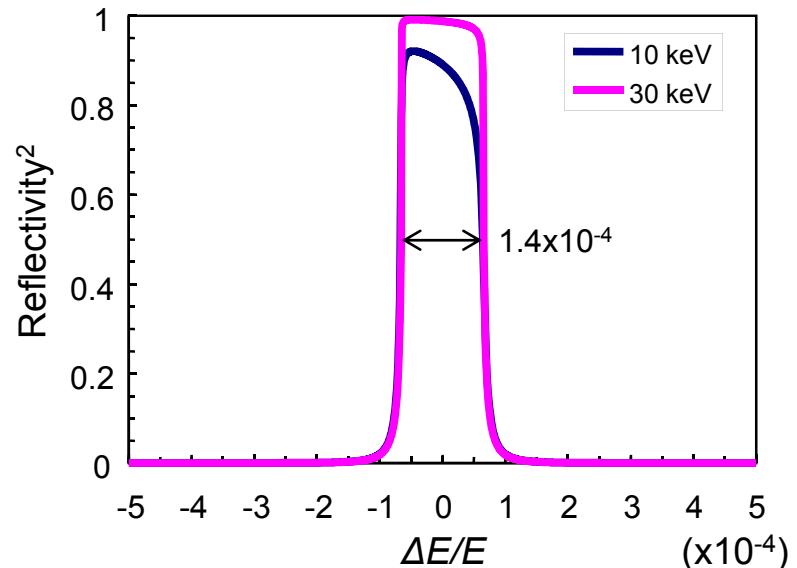
$$\frac{\Delta E}{E} = -\frac{\Delta \lambda}{\lambda} \approx \frac{|\chi_{hr}|}{\sin^2 \theta_B}$$

$$= 4d_{hkl}^{-2} \frac{|\chi_{hr}|}{\lambda^2}$$

$$\frac{\Delta E}{E} = -\frac{\Delta \lambda}{\lambda} \propto d_{hkl}^{-2} f^0(d_{hkl})$$



Independent of photon energy



e.g. for Si 111 refl. DCM case

Note relative energy width is constant.

# Effective band width (Integrated intensity)

For single-bounce monochromator

$$\frac{\Delta E}{E} = \frac{|\chi_{hr}|}{2 \sin^2 \theta_B} \int R(W) dW$$

$$= \frac{8}{3} \cdot \frac{|\chi_{hr}|}{2 \sin^2 \theta_B}$$

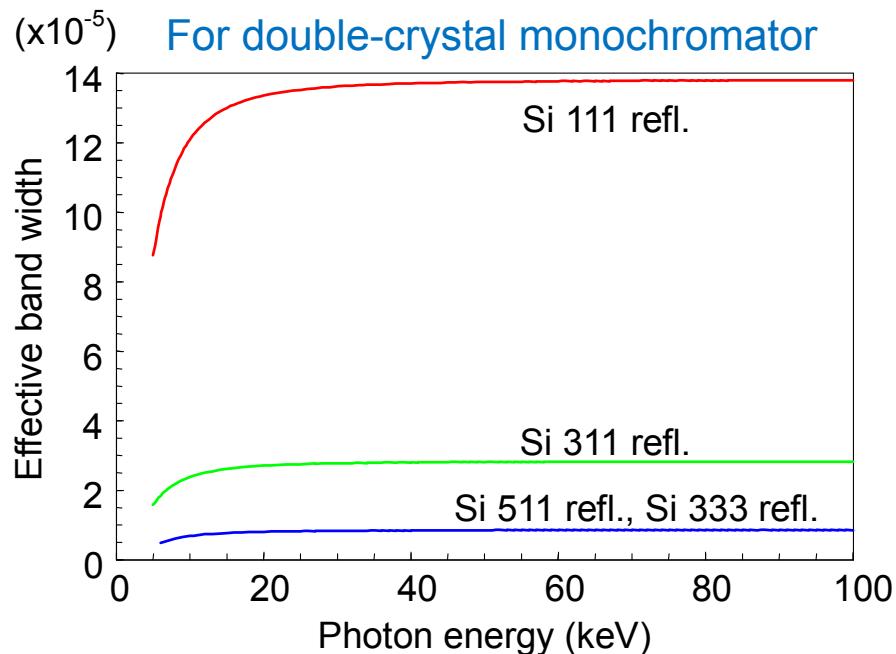
↑ For no absorption

For double-crystal monochromator

$$\frac{\Delta E}{E} = \frac{|\chi_{hr}|}{2 \sin^2 \theta_B} \int R(W)^2 dW$$

$$= \frac{32}{15} \cdot \frac{|\chi_{hr}|}{2 \sin^2 \theta_B}$$

↑ For no absorption



Effective band-width is obtained  
by integration of reflection curve.

When you need flux → Lower order (Si 111 refl.,...)

When you need resolution → Higher order (Si 311, Si 511 refl.,...)

# Photon flux estimation

## Effective band width

Reflection (nominal energy)	Effective band width
Si 111 DCM (6 keV)	1.0045x10 <sup>-4</sup>
Si 111 DCM (8 keV)	1.1399x10 <sup>-4</sup>
Si 111 DCM (10 keV)	1.2216x10 <sup>-4</sup>
Si 111 DCM (12 keV)	1.2710x10 <sup>-4</sup>
Si 111 DCM (14 keV)	1.3021x10 <sup>-4</sup>
Si 333 DCM (14 keV)	8.0996x10 <sup>-6</sup>

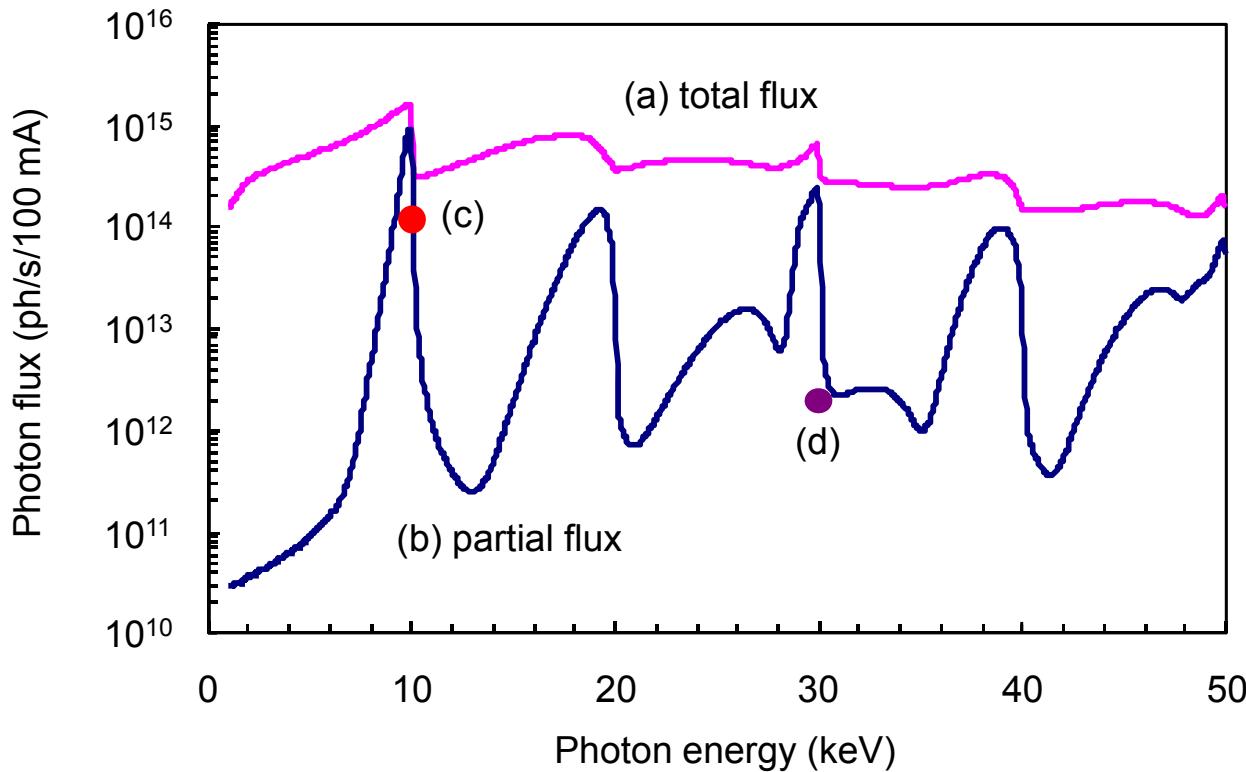
$$Flux = \int S(E, \phi) R(E, \phi)^2 dE d\phi$$

## Photon flux (ph/s/100mA/20 μrad(H))

(A) SPECTRA × Effective band width  $\Leftrightarrow$  (B) SPECTRA × DuMond

Reflection	Flux (A)	Flux (B)
Si 111 DCM (6 keV)	5.68x10 <sup>13</sup>	5.70x10 <sup>13</sup>
Si 111 DCM (8 keV)	6.14x10 <sup>13</sup>	6.15x10 <sup>13</sup>
Si 111 DCM (10 keV)	6.01x10 <sup>13</sup>	6.02x10 <sup>13</sup>
Si 111 DCM (12 keV)	5.28x10 <sup>13</sup>	5.29x10 <sup>13</sup>
Si 111 DCM (14 keV)	4.20x10 <sup>13</sup>	4.20x10 <sup>13</sup>
Si 333 DCM (14 keV)	2.62x10 <sup>12</sup>	2.61x10 <sup>12</sup>

# Photon flux at undulator beamline



- (a) Total flux @ 0.1% b.w.
- (b) After frontend slit  
 $1 \times 1 \text{ mm}^2$  @30 m
- (c) Si 111 refl. @10 keV  
Effective b.w. =  $1.3 \times 10^{-4}$
- (d) 3<sup>rd</sup> harmonics @30 keV  
Effective b.w. =  $8.0 \times 10^{-6}$

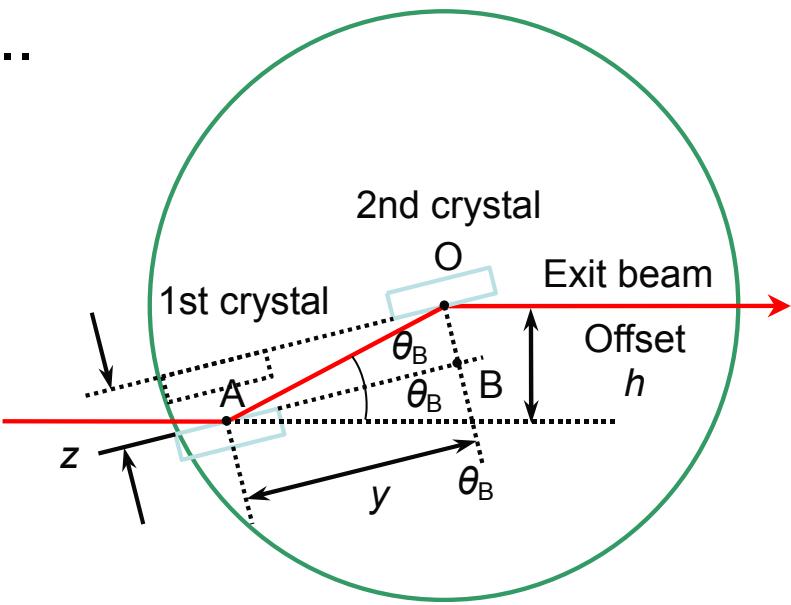
Higher harmonics elimination more → mirror or detuning of DCM

We can obtain photon flux of  $10^{13}\sim 10^{14}$  ph/s/100 mA/mm<sup>2</sup> using standard undulator sources and Si 111 reflections at SPring-8 beamlines.

# Double-crystal monochromator

- Fixed-exit operation for usability at experimental station.
- Choose suitable mechanism for energy range (Bragg angle range).
- Precision, stability, rigidity,...

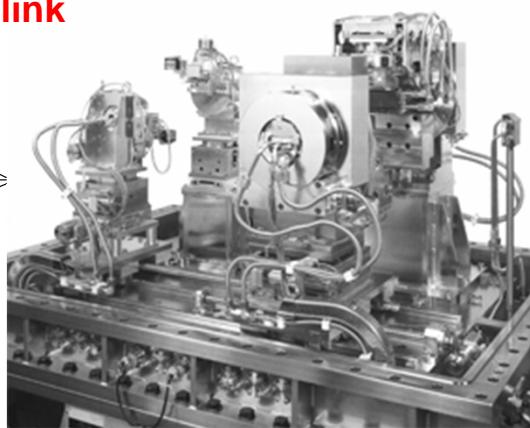
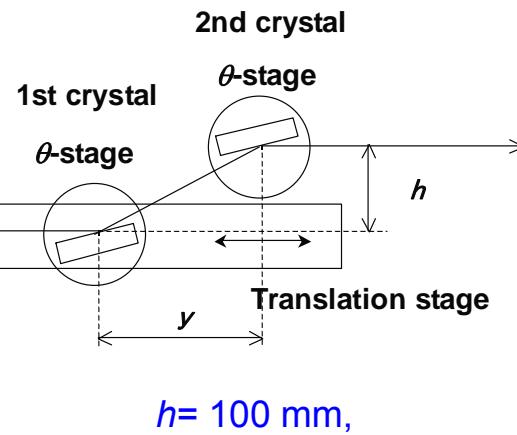
$$y = AB = \frac{h}{2 \sin \theta_B}$$
$$z = OB = \frac{h}{2 \cos \theta_B}$$



Fixed-exit operation using rotation ( $\theta$ ) + two translation mechanism 50

# e.g. Double-crystal monochromator

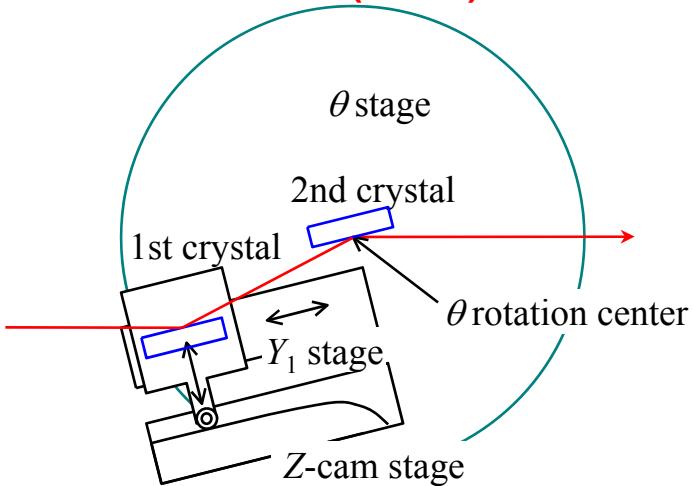
$\theta_1 + \text{translation} + \theta_2$  computer link



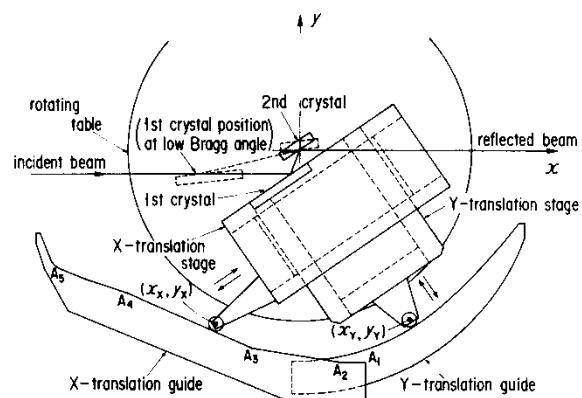
$h = 100 \text{ mm}$ ,

$\theta_B = 5.7 \sim 72^\circ$  (for lower energy range)

$\theta + \text{two translation (1 cam)}$



$\theta + \text{two translation (2 cams)}$



KEK-PF BL-4C

Matsushita et al., NIM A246 (1986)

Offset  $h = 30 \text{ mm}$   
 $\theta_B = 3 \sim 27^\circ$  for higher energy range

SPring-8 std. DCM

# Crystal cooling

## Why crystal cooling ?

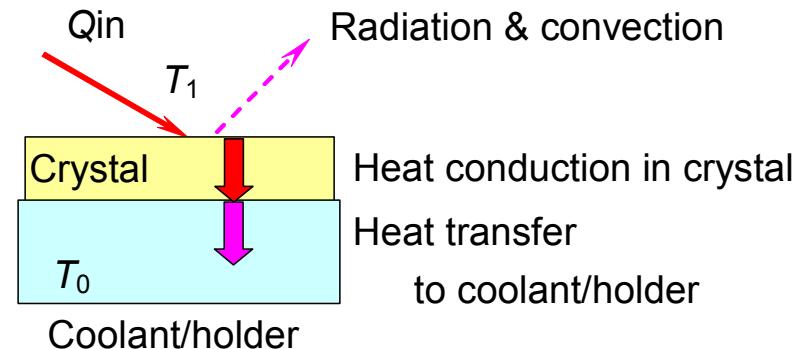
$$Q_{in} (\text{Heat load by SR}) = Q_{out} (\text{Cooling + Radiation, ...})$$

→ with temperature rise  $\Delta T$

→  $\alpha \Delta T = \Delta d$  ( $d$ -spacing change)

$\alpha$ : thermal expansion coefficient

or →  $\Delta\theta$  (bump of lattice due to heat load)



## Miss-matching between 1st and 2nd crystals occurs:

→ Thermal drift, loss of intensity, broadening of beam, loss of brightness

→ Melting or limit of thermal strain → **Broken !**

## We must consider:

- Thermal expansion of crystal:  $\alpha$ ,
- Thermal conductivity in crystal:  $\kappa$ ,
- Heat transfer to coolant and crystal holder.

## Solutions:

(S-1)  $\kappa/\alpha \rightarrow$  Larger

(S-2) Contact area between crystal and coolant/holder  
→ larger

(S-3) Irradiation area → Larger,  
and power density → smaller

## Figure of merit

	Silicon	Silicon	Diamond
$\kappa$ (W/m/K)	300 K	80 K	300 K
$\alpha$ (1/K)	150	1000	2000
$\kappa/\alpha \times 10^6$	$2.5 \times 10^{-6}$	$-5 \times 10^{-7}$	$1 \times 10^{-6}$

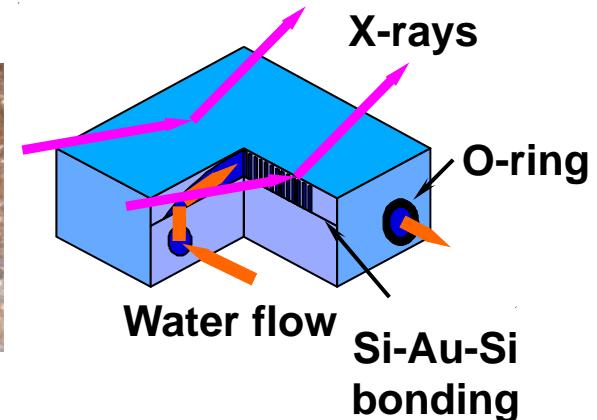
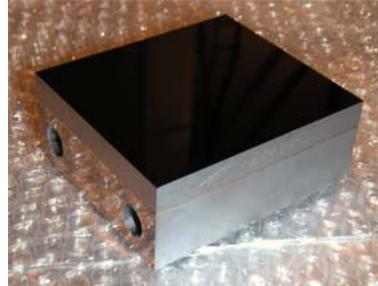
Figure of merit of cooling:  
Good for silicon (80 k)  
and diamond (300 K)

# Crystal cooling at SPring-8

## <Bending magnet beamline>

Power & power density:  
~100 W, ~1 W/mm<sup>2</sup>

### Fin crystal direct-cooling - (S2)

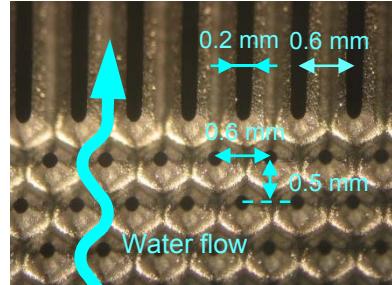
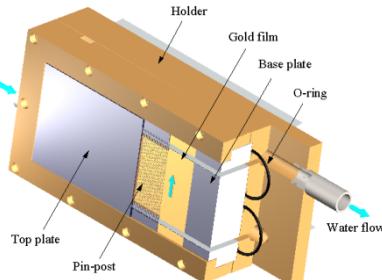


## <Undulator beamline>

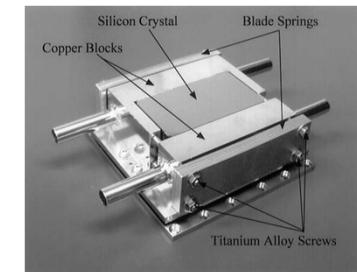
Linear undulator,  $N= 140$ ,  $\lambda_u= 32$  mm

Power & power density: 300~500 W ,  
300~500 W/mm<sup>2</sup>

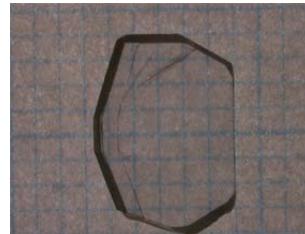
### a) Direct cooling of silicon pin-post crystal – (S2) & (S3)



### b) Silicon cryogenic cooling - (S1)



### c) Ila diamond with indirect water cooling - (S1)

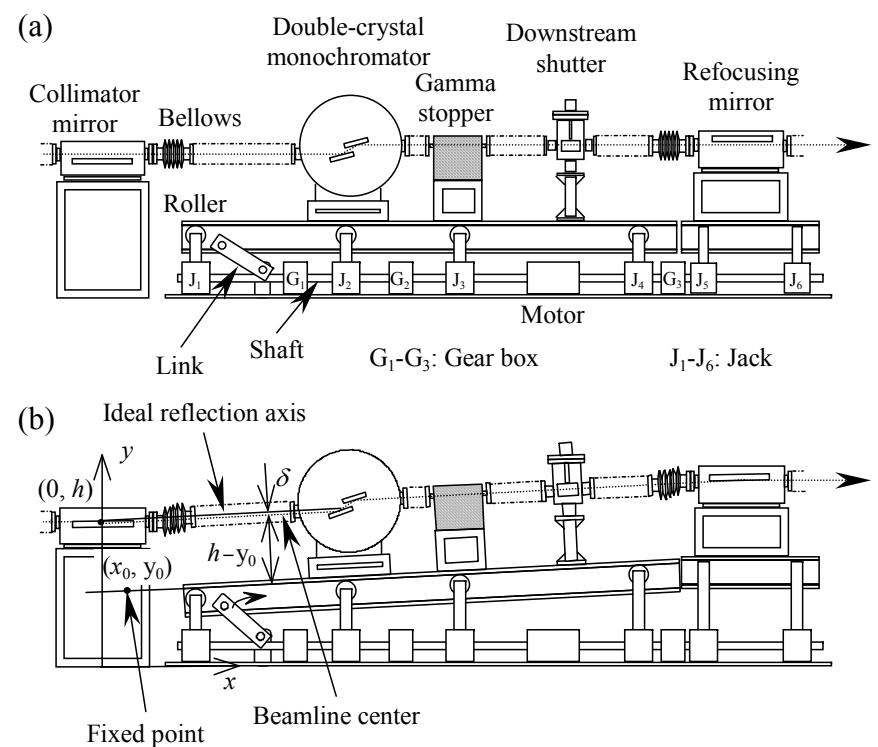
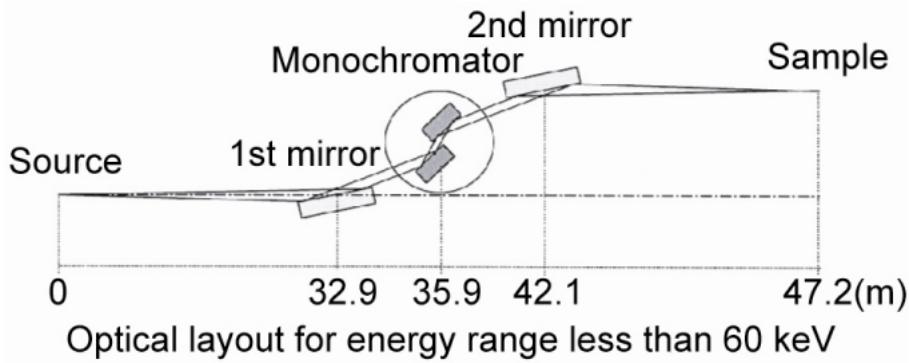


# **Example of x-ray beamline**

## **- SPring-8 case -**

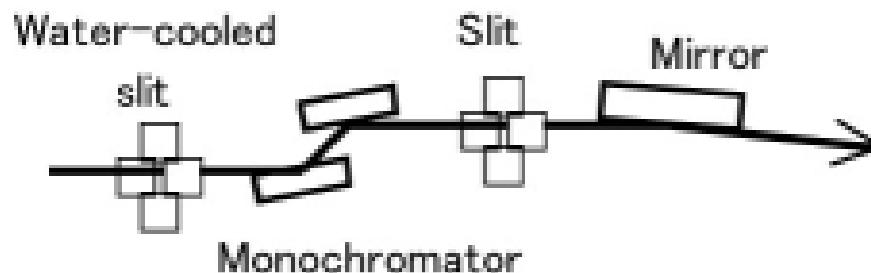
# XAFS & single crystal diffraction

- Bending magnet
- Collimator mirror,
- + DCM,
- + refocusing mirror

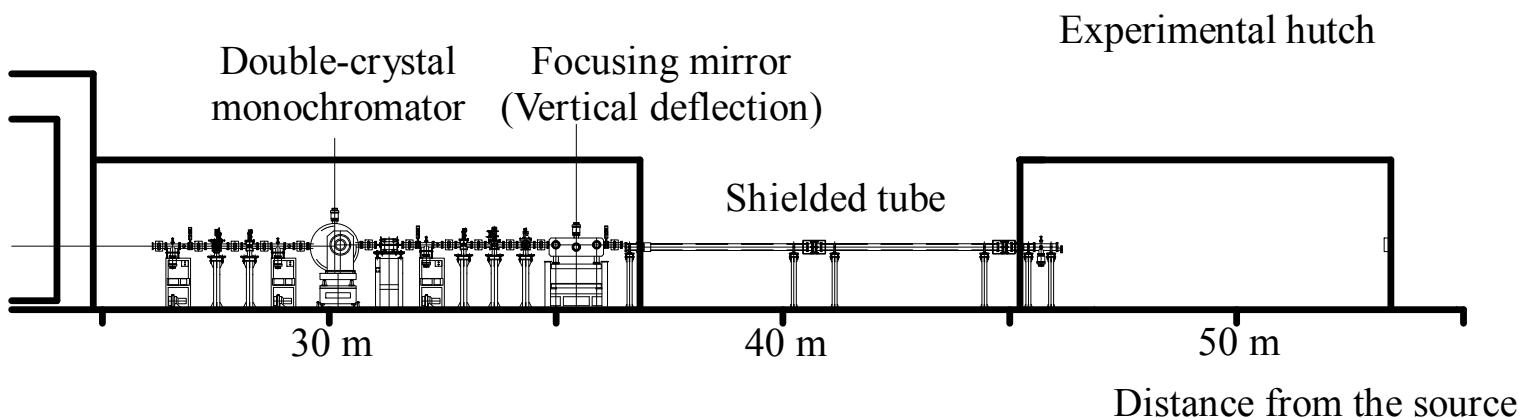


# Protein crystallography

- Bending magnet
- DCM + focusing mirror

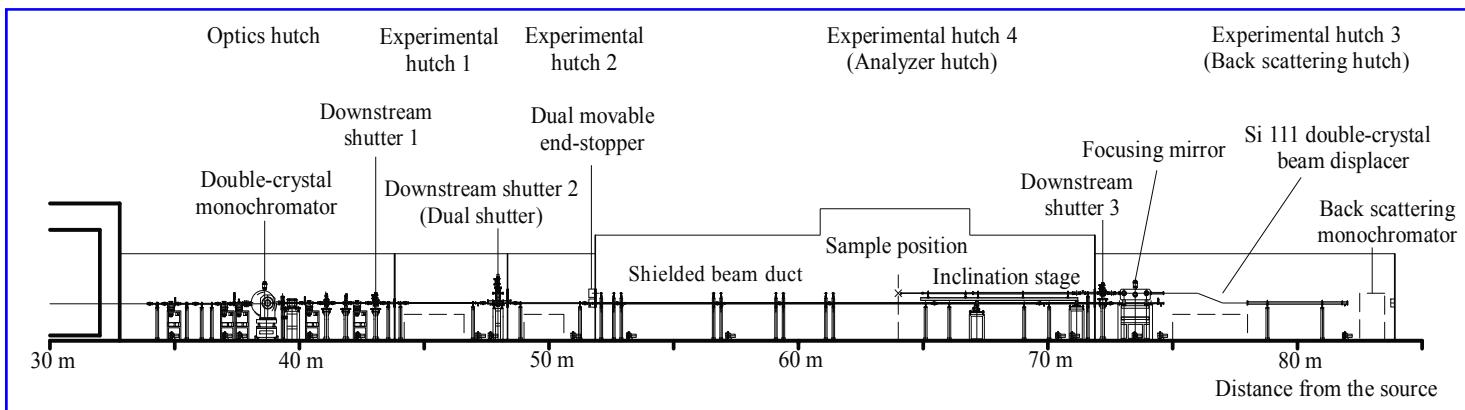
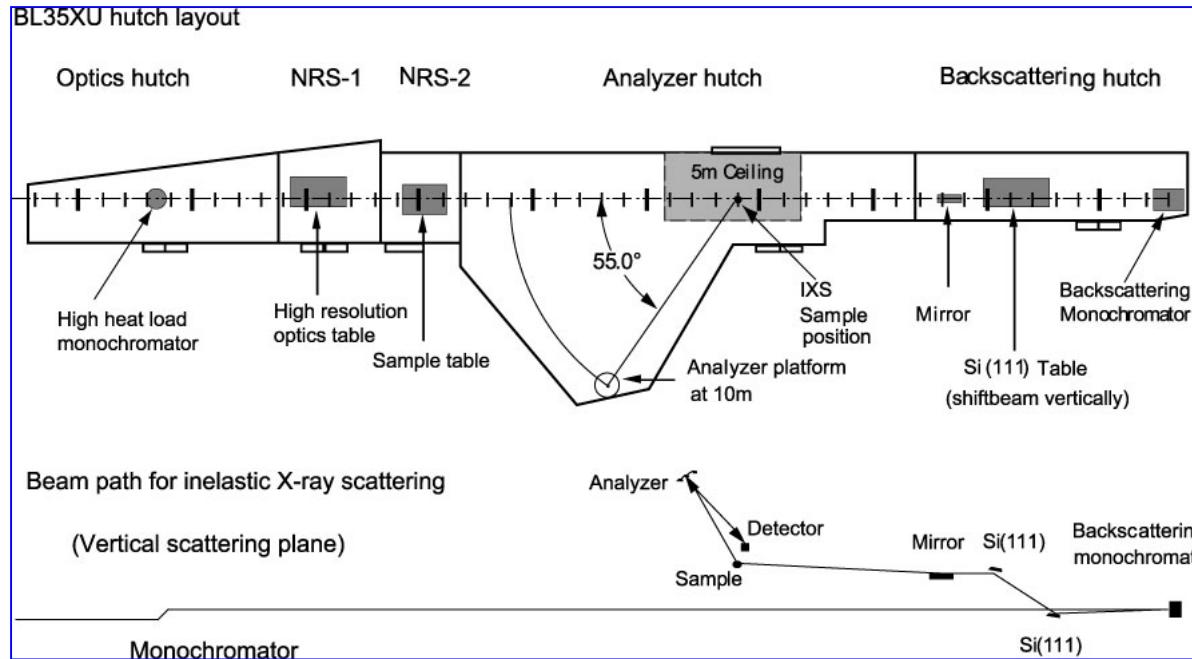


Optics hutch with standard components



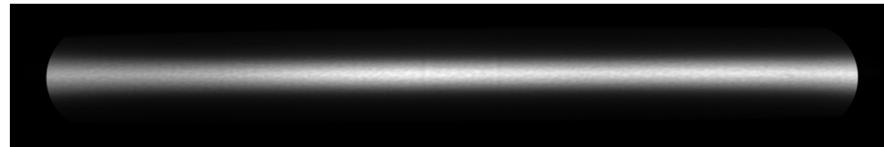
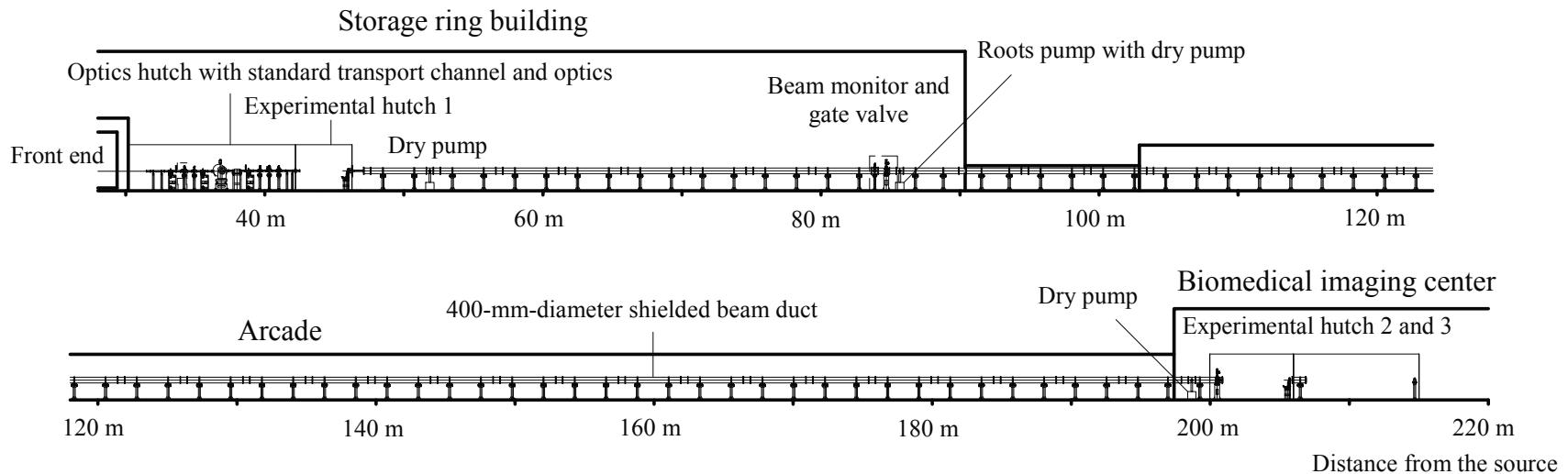
# High resolution inelastic scattering

- Undulator
- DCM + back-reflection monochromator & analyzer (w/  $\sim$ meV resolution)



# 200-m-long beamline

- Bending magnet
- DCM



300-mm-wide beam at end-station

# Summary

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Key issues on the x-ray **monochromator** were shown,  
introducing the **dynamical x-ray diffraction** for **large & perfect crystal**,  
w/ several important points:

- 1) Total reflection occurs at the gap between dispersion surfaces.
- 2) Normalized deviation parameter  $W$  is related to the gap.
- 3)  $W$  is parameter of angular deviation and energy (wavelength) deviation.  
It gives **DuMond diagram** as a band of  $|W|<1$ .
- 4) By combination of light source and monochromator crystals,  
photon energy, energy resolution, photon flux, ... can be controlled / tuned.

Double-crystal monochromator w/ crystal cooling is needed for practical use  
at the SR beamline.

By understanding these, you will be approaching to good design/use of the beamline  
for your SR science.

# Text books following Laue's dynamical theory

Ergebnisse der Exakt Naturwiss.

10 (1931) 133-158.

Die dynamische Theorie der Röntgenstrahlinterferenzen in neuer Form.

Von M. v. LAUE, Berlin.  
Mit 4 Abbildungen.

Inhaltsverzeichnis.

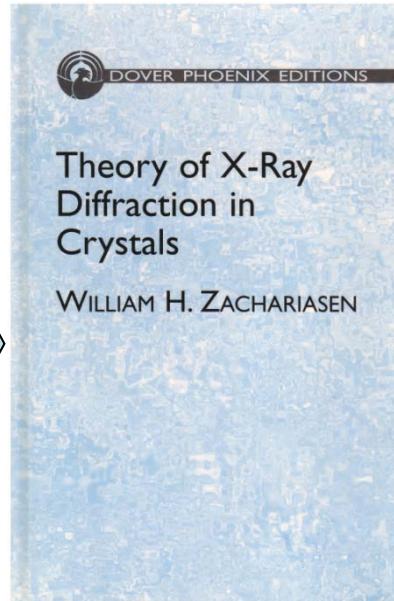
§ 1. Die dynamische Grundgleichung . . . . .	137
§ 2. Annäherungen in der Lösung der Grundgleichung (I) . . . . .	141
§ 3. Die einfachsten Beispiele für nichtabsorbiendes Kristall . . . . .	144
§ 4. Die Theorie über Realität der Dispersionstheorie . . . . .	149
§ 5. Die Reflexion von Röntgenstrahlen an den Grenzen von schreibenden Kristalle . . . . .	153

EWAUD dynamische Theorie der Röntgenstrahlinterferenzen! gehört nach unserer Ansicht auf alle Zeiten zu den Meisterwerken der mathematischen Physik. Sie bestätigte mit glänzenden Methoden ein zunächst schier unlösbares Problem, rechtfertigte eigentlich erst die elementare, rein auf Phasenzusammensetzung beruhende Theorie, die die Unmöglichkeit quantitativ abzuschätzen lehrte, z. B. die Verbindung mit der optischen Dispersionstheorie. Abweichungen von den Ergebnissen der älteren Theorie spielen vor allem die Differenz der Dispersion des Hafers und des Goldes für eine exakte Messung der Winkel aus, die möglich würden. Aber wir glauben aussprechen zu dürfen, daß es nur wenigen, die ihre Resultate oft benutzen, nicht allzu viele durchgearbeitet haben. Denn jene glänzenden mathematischen Methoden waren nicht nur schwierig zu finden, sie bereiten in manchen Teilen auch dem Leser Schwierigkeiten. Daran hat auch die Neubearbeitung durch WALLER<sup>a</sup> nicht viel geändert, welche im übrigen das Verdienst besitzt, zuerst Gitter mit Basis in die Rechnung einzbezogen zu haben. Der Zweck der folgenden Schrift ist es, Themen, die jetzt mehr verständlich sind, darzustellen. Da wir nichts weiteren Voraussetzungen auf neue Ergebnisse die neue Form verfeinern, scheint uns durch die Wichtigkeit der Sache gerechtfertigt; ebenso, daß wir, um dem Leser das Zurückgreifen auf die genannten Arbeiten zu erleichtern, die geometrische Diskussion EWAUDs nochmals zum Abdruck bringen, obwohl wir an ihr fast nichts zu ändern brauchen.

<sup>a</sup> EWAUD, P. P.: Ann. Physik 54, 519, 557 (1917); Z. Physik 2, 332 (1920); 30, 1 (1924).

<sup>b</sup> WALLER, J.: Uppsala Universitets Årskrift 1925.

Dover (1945)



R. W. James  
“The Dynamical Theory of X-Ray Diffraction”  
Solid State Physics 15,  
(1963) 53-220.

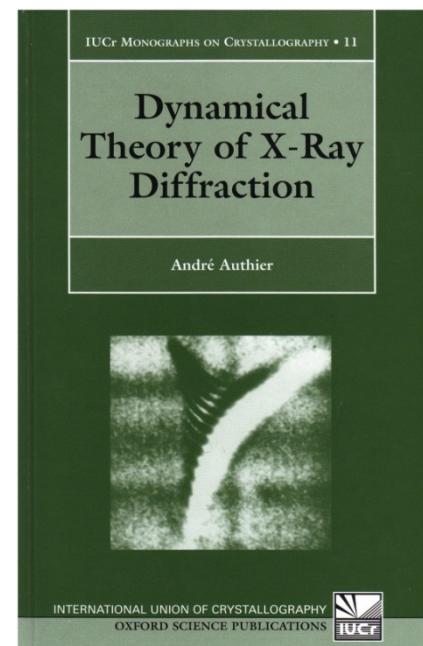
B. W. Batterman & H. Cole

“Dynamical Diffraction of X-Rays by Perfect Crystals”

Rev. Modern Phys. 36,  
(1964) 681-717.

Springer (2004)

Oxford (2001)



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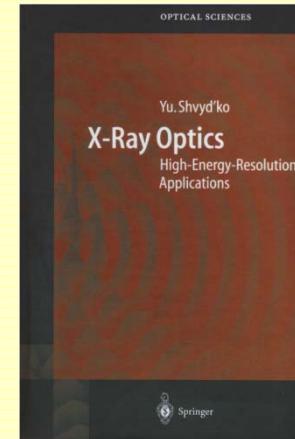
Yu. Shvyd'ko  
**X-Ray Optics**  
High-Energy-Resolution Applications

Springer

# References

## For monochromator

- [1] T. Matsushita & H. Hashizume,  
Handbook on Synchrotron Radiation Vol. 1,  
North-Holland (1983).
- [2] Y. Shvyd'ko, Springer (2004), *for high energy resolution*



## For atomic scattering factor

➤ For  $f^0$

- [3] International Tables for X-ray Crystallography (IUCr).  
[4] Hubbell et al.: J. Phys. Chem. Ref. Data Vol. 4, No. 3, 1975.

➤ For anomalous scattering factor  $f'$ ,  $f''$

- [5] S. Sasaki, KEK report 88-14 (1989),  
[6] Tables of LBNL (B. L. Henke et al.),  
[http://henke.lbl.gov/optical\\_constants/index.html](http://henke.lbl.gov/optical_constants/index.html),  
[7] Tables of NIST,  
<http://physics.nist.gov/PhysRefData/FFast/html/form.htm>